

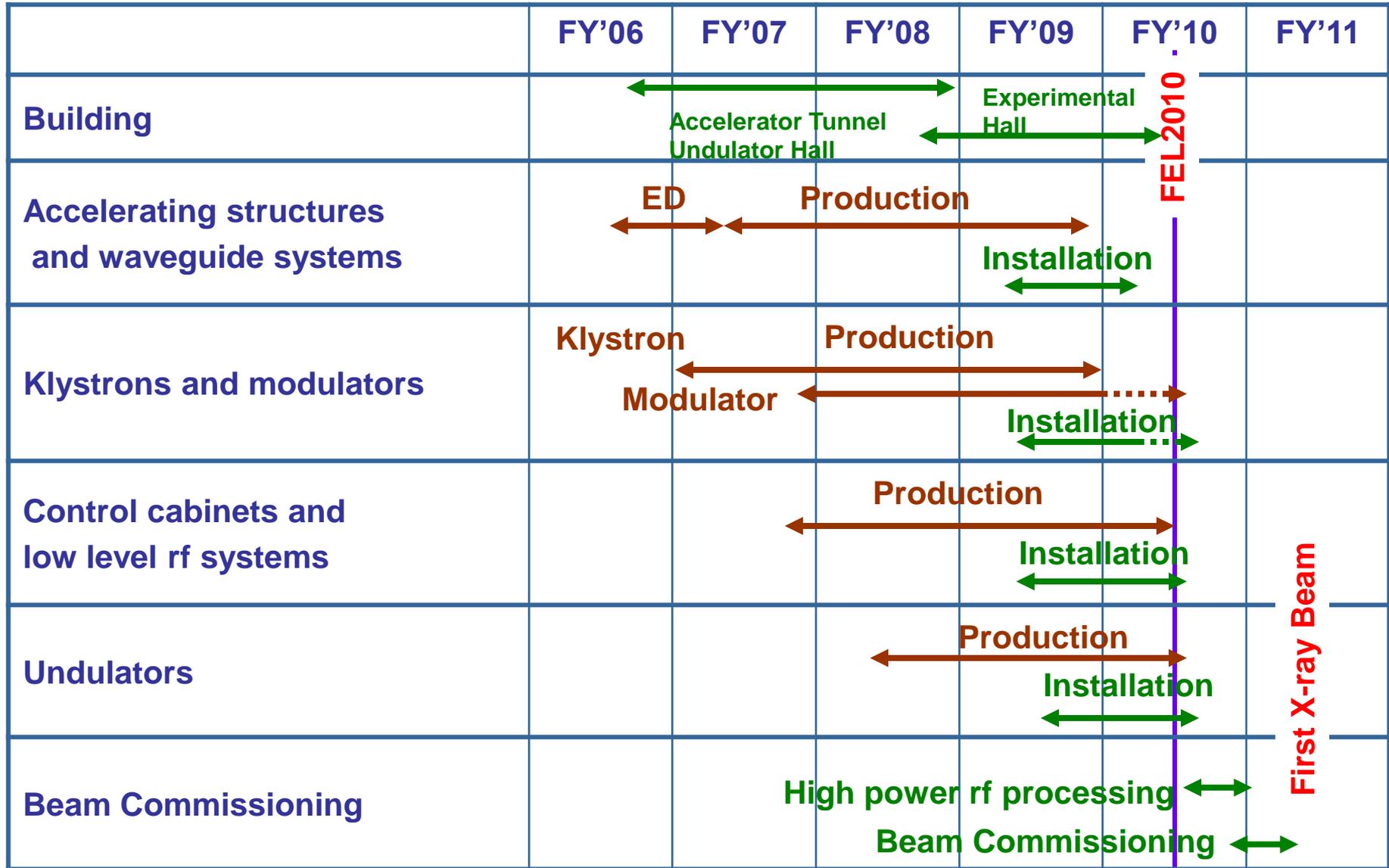
XFEL/SPring-8 Construction and SCSS EUV Laser Operation Status

Tsumoru Shintake

as representing Joint XFEL/SPring-8 Construction Team

**R&D Technical Director XFEL/SPring-8
Chief Scientist RIKEN SPring-8 Center**

Status of XFEL/SPring-8 Construction



SPring-8/XFEL and SCSS

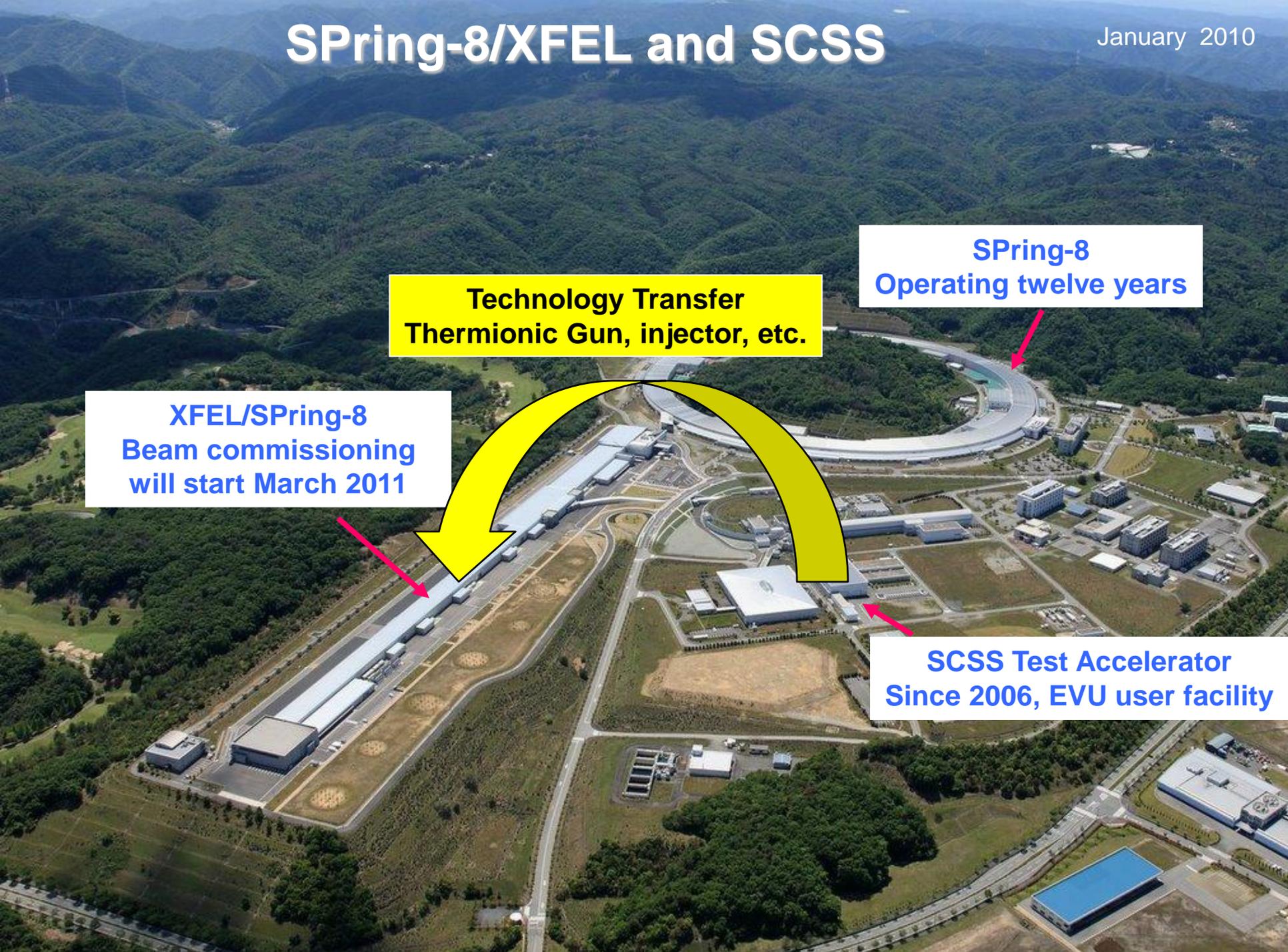
January 2010

SPring-8
Operating twelve years

Technology Transfer
Thermionic Gun, injector, etc.

XFEL/SPring-8
Beam commissioning
will start March 2011

SCSS Test Accelerator
Since 2006, EVU user facility





50 m Experimental Hall

200 m Undulator Hall

400 m Accelerator Tunnel

Klystron Gallery

Machine Assembly Hall

2007 May



2007 Dec



Excavating 17 m deep at undulator area, replaced with crashed stones on base rock, which took 8 month. Only -1.7 mm vertical movement was observed for 2 year after completion. Extremely stable basement was made for undulator hall.

2008 May



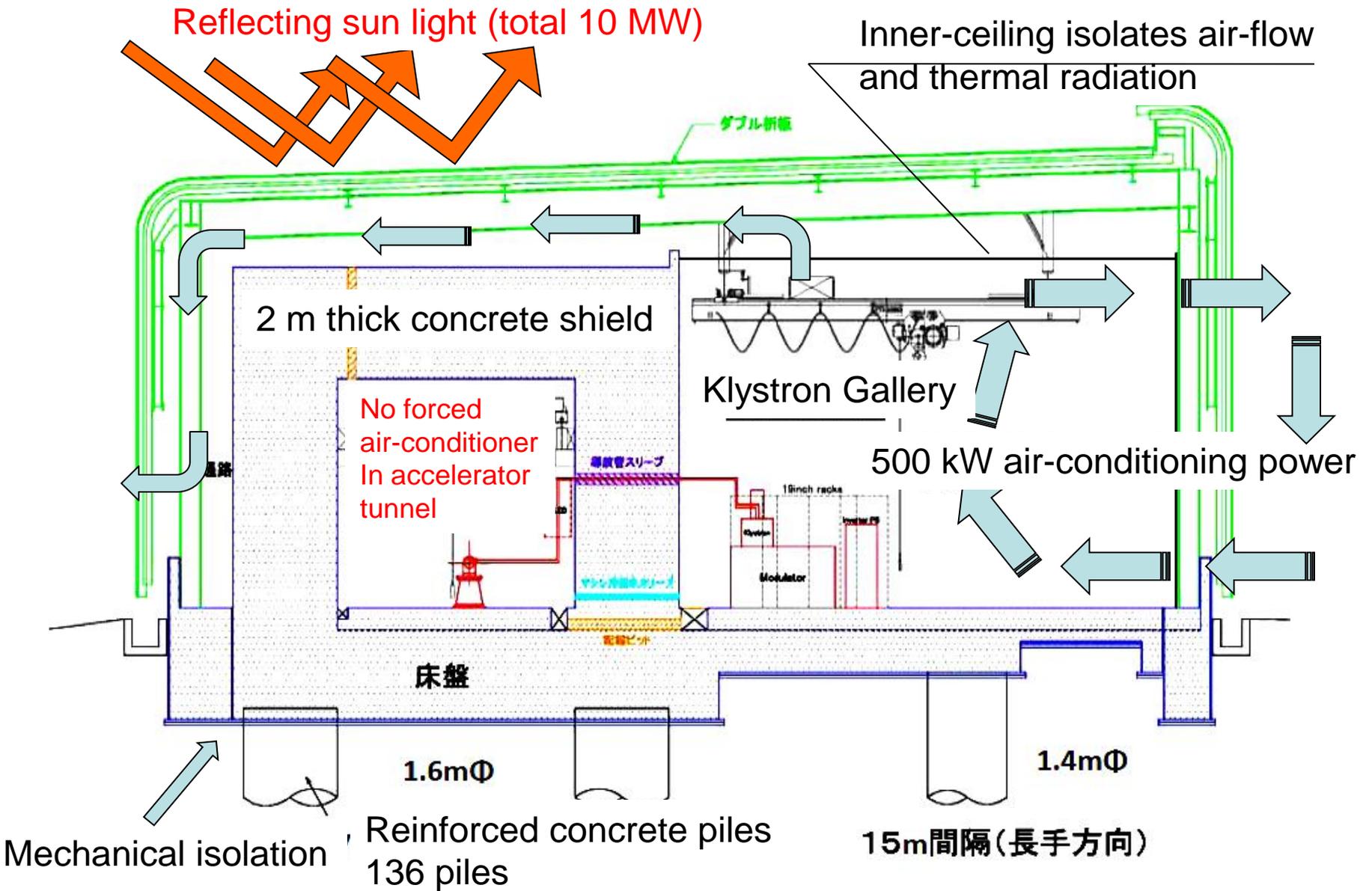
2008 Oct



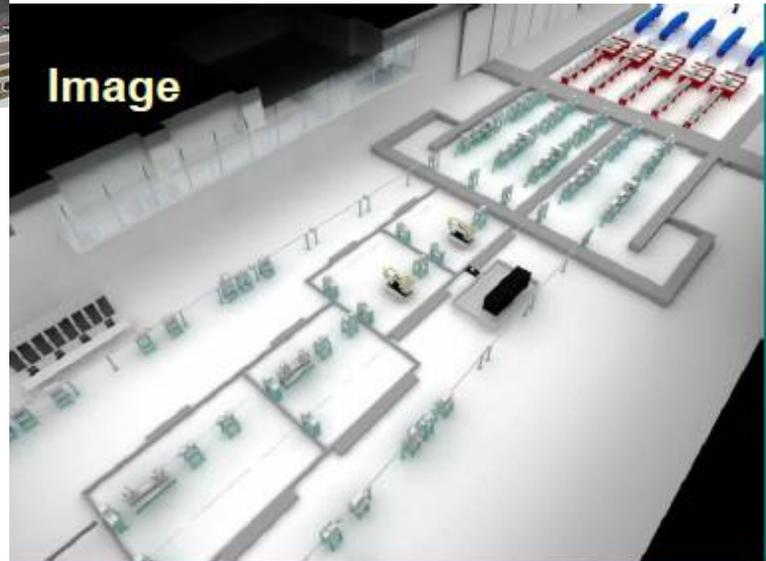
2009 April



Temperature Regulation 1 deg was achieved for Non-under Ground Tunnel



Experimental Hall



Beam Lines

Beamline

5 beamlines (final)

Start from BL3 (XFEL) & BL1 (SX)

4 Experimental Hutches

EH1: R&D

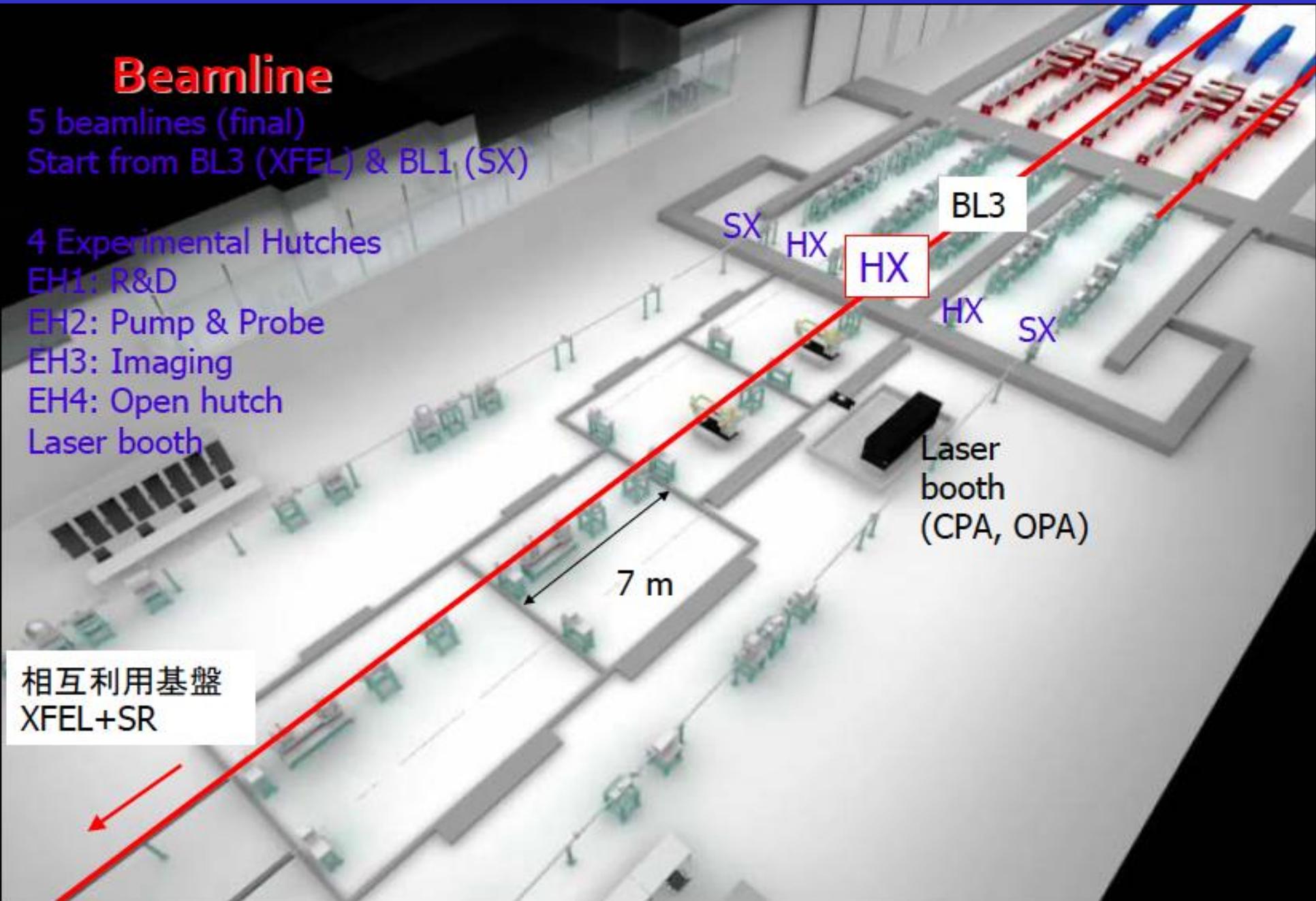
EH2: Pump & Probe

EH3: Imaging

EH4: Open hutch

Laser booth

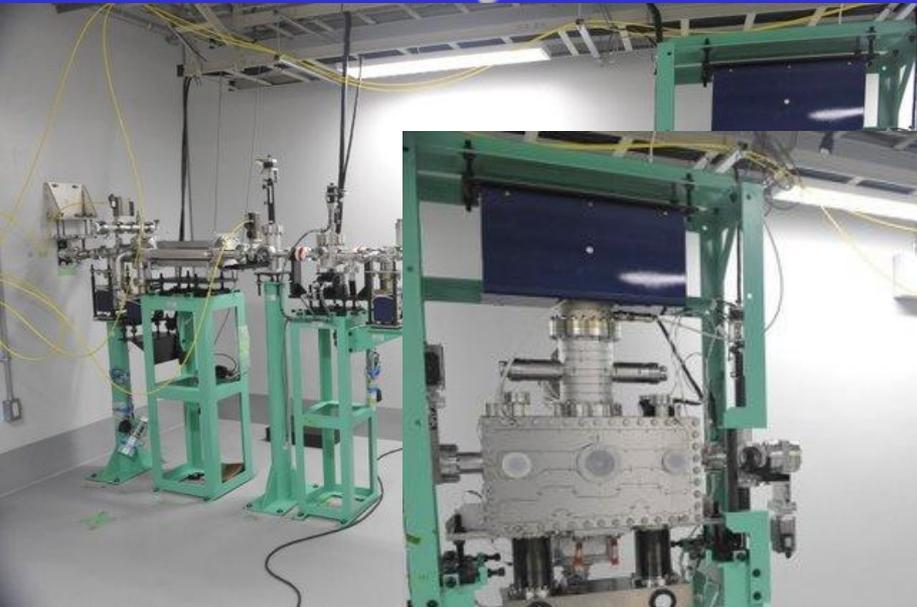
相互利用基盤
XFEL+SR



Experimental Hall, 4 Hutches are ready



X-ray Beam Line Front-End Mirrors



2009 July



Accelerator installation



2009 Aug



2009 Aug



2010 May



WEOC3

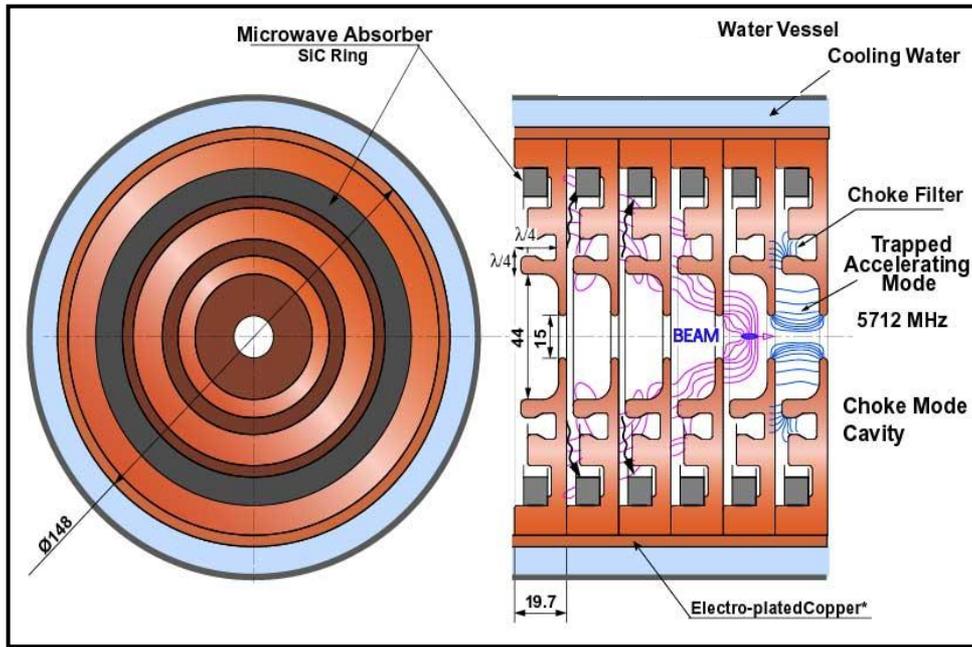
T. Inagaki, "Construction of 8-GeV C-band Accelerator for XFEL/SPring-8",

SCSS/XFEL Status
April, 2010

19

Tsumoru Shintake
shintake@spring8.or.jp

C-band Accelerator for Multi-bunch Option



T. Shintake, "Choke Mode Cavity",
Jpn. J. Appl. Phys. Vol. 31 pp. L1567-L1570, November 1992



13,000 cells are under mass production.



Sadao Miura, MITSUBISHI Heavy Ind, April 2010

Higher Order Mode Damping for Multi-bunch operation.
Maximum 50 bunches x 1 nC, at 4.2 nsec spacing

X-ray 4.2 nsec x 50 bunches will be key for
Single bio-molecule imaging to improve Luminosity.

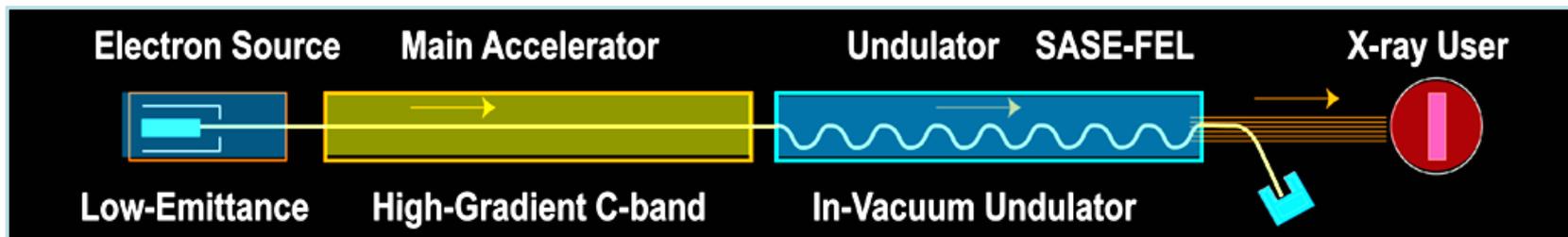
Testing Modulator & Klystron



May 2010



SCSS : SPring-8 Compact SASE Source



■ Short Period Undulator



Lower Beam Energy

In-Vacuum Undulator : $\lambda_u = 18$ mm, $K=1.9$, $\lambda_x < 1$ Å \rightarrow $E = 8$ GeV,

SLAC-LCLS : $\lambda_u = 30$ mm, $K=3.7$, $\lambda_x \sim 1.5$ Å \rightarrow $E = 14$ GeV

Euro-XFEL : $\lambda_u = 36$ mm, $K=3.3$, $\lambda_x < 1$ Å \rightarrow $E = 17.5$ GeV

■ High Gradient Accelerator



Short Accelerator Length

8 GeV, C-band 35 MV/m \rightarrow 230 m

SLAC-LCLS : S-band 19 MV/m \rightarrow 740 m

■ Thermionic Electron Source



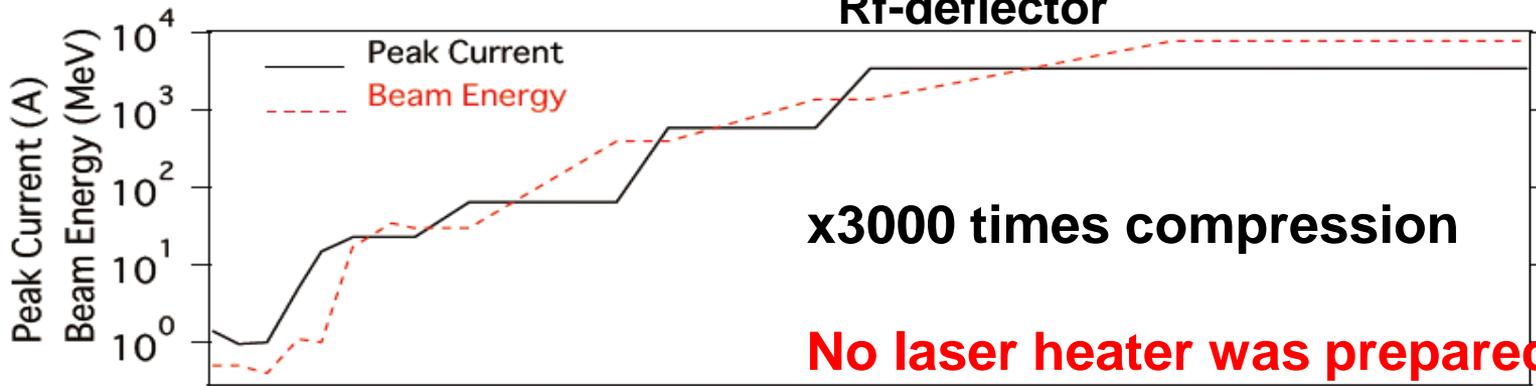
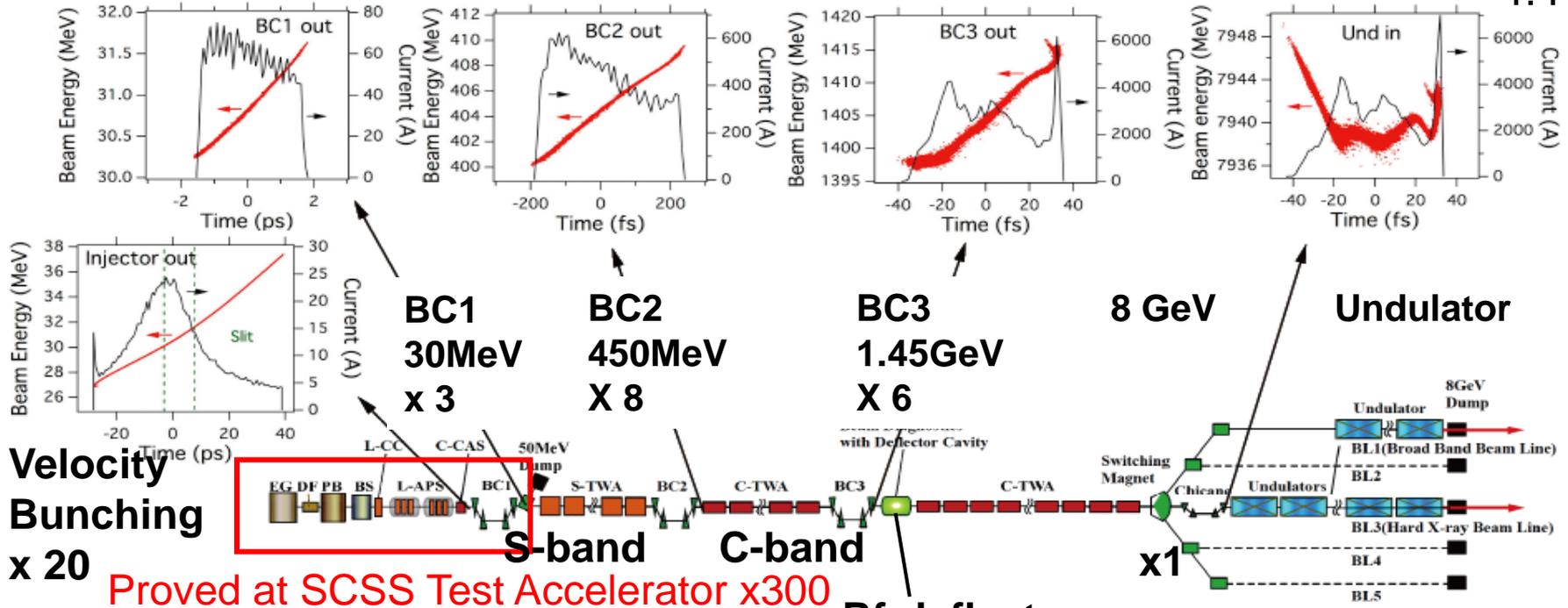
Short Saturation Length

Thermionic gun + velocity bunching \rightarrow 0.8 π .mm.mrad @ 3k A, 8GeV

\rightarrow multi-bunch operation, smooth & quiet beam for seeding

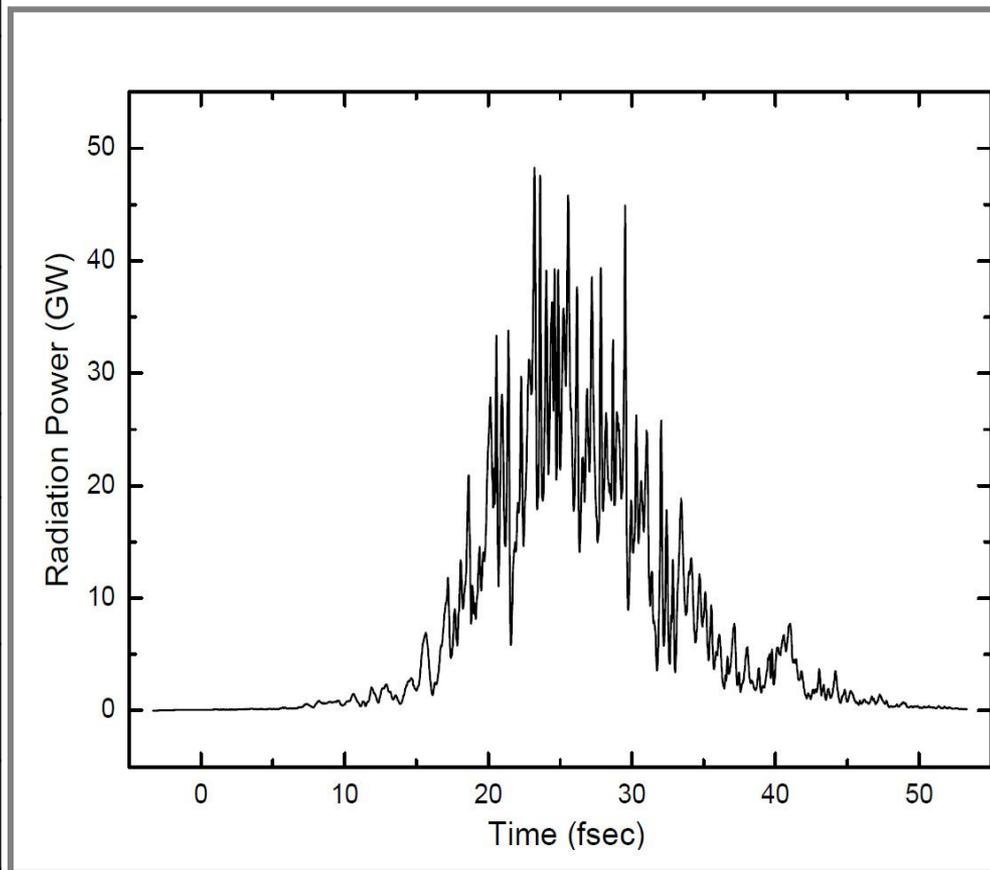
Beam Acceleration and Compression

T. Hara



Expected Performance of XFEL/SPring-8

Wavelength	< 0.1 nm
Peak Power	~ 20 GW
X-ray Pulse Length	200 fs ~ 20 fs
X-ray Pulse Energy	Max 0.4 mJ
Photon Flux	2×10^{11} p/pulse
Peak Brightness	1×10^{33} p/mm ² /mrad ² /0.1% BW
X-ray Pulse Repetition	10 ~ 3000 pps (50 bunch x 60 Hz)
Bunch per Pulse	1 ~ 50 (4.2 nsec spacing)
e Beam	8 GeV x 0.3 nC 0.8 π mm.mrad, 3 kA



**Expected X-ray pulse of 0.1 nm
(SIMPLEX simulation)**

Use Small Size Cathode

...First Strategy for smaller thermal emittance

Thermal Emittance

$$\epsilon_{xN} = \frac{\gamma r_c}{2} \sqrt{\frac{k_B T}{m_0 c^2}} = 0.4 \pi \text{ mm-mrad}$$

Operating Temperature 1500° C

$$w_e = \frac{3}{2} k_B T = 223 \text{ meV}$$

Use Small Cathode **3mm**



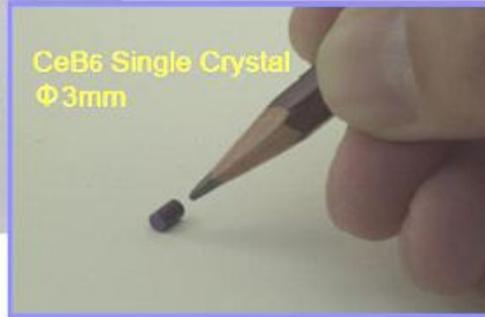
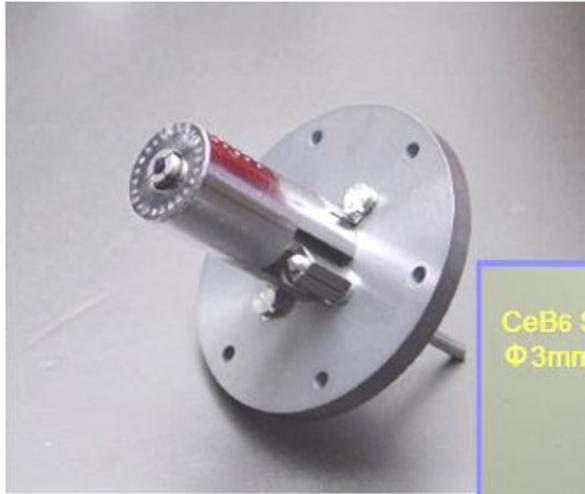
Current Density

$$\frac{I_e}{\pi r_c^2} = \frac{1 \sim 2 \text{ A}}{3.1 \times 0.15_{\text{cm}}^2} = 14 \sim 30 \text{ A/cm}^2$$

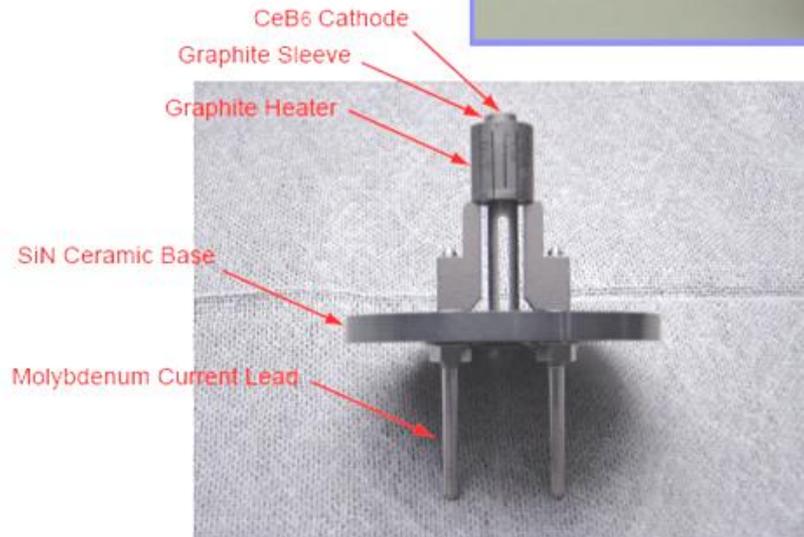
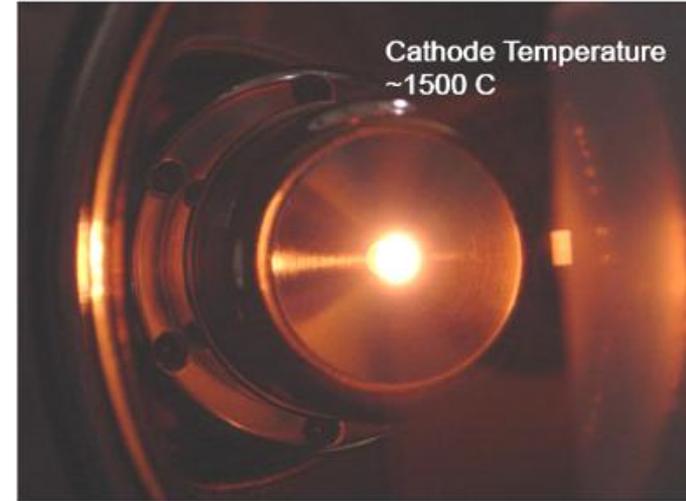
LaB₆ or CeB₆

Twice longer lifetime

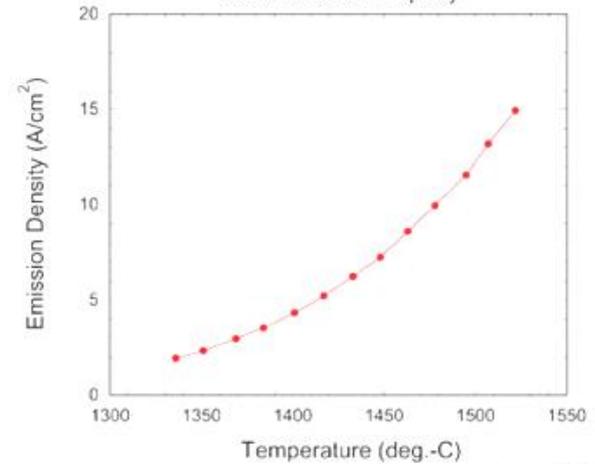
Cathode Assembly



Heated Cathode in Stem



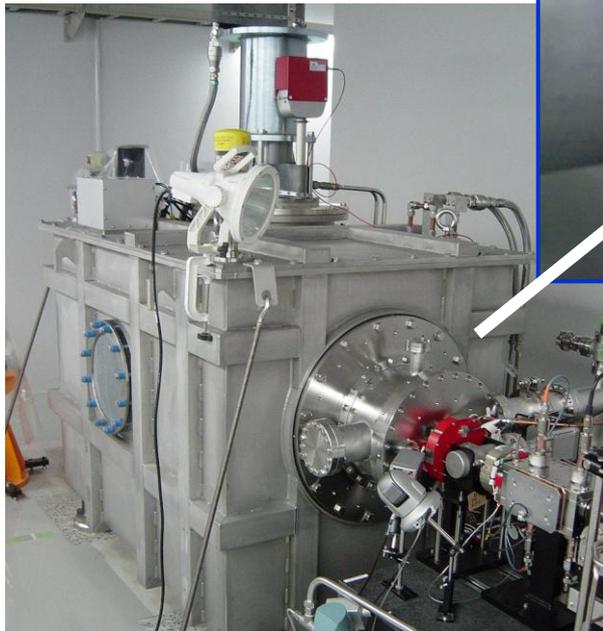
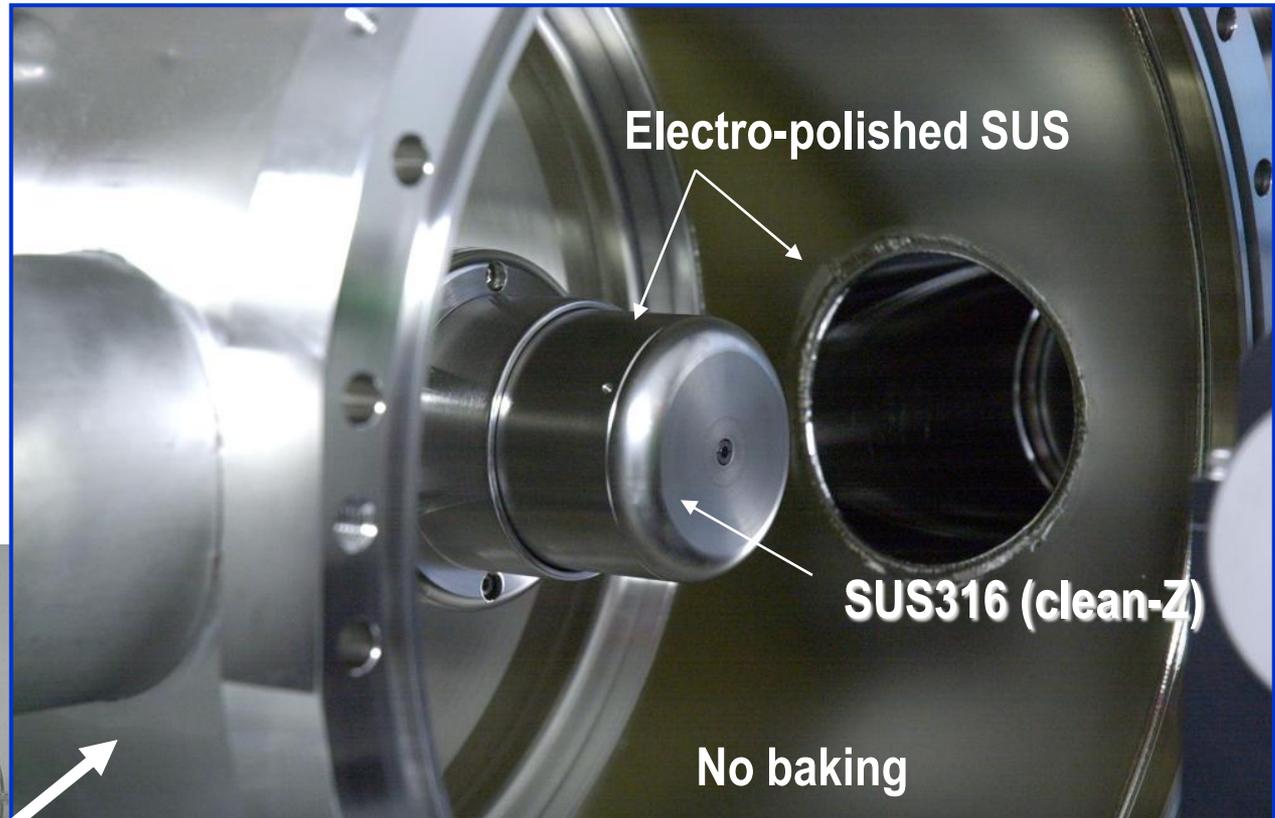
CeB6 Emission Property



The gun voltage=500 kV
Temperature was measured at the sleeve by a radiation monitor.

Operational Experience of 500 kV Gun

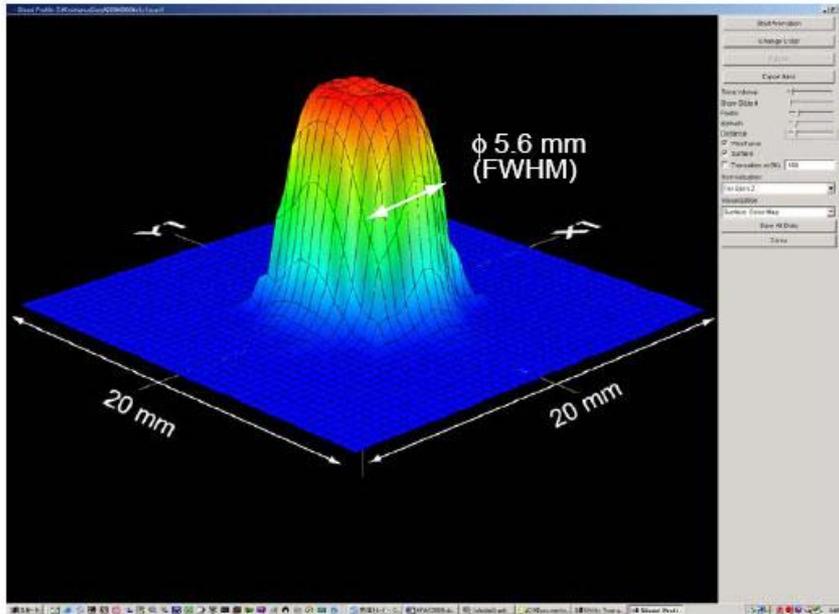
- Applying 500 kV pulse.
- 3 micro-sec pulse driven by klystron modulator.
- Gun sits inside HV pulse tank, filled with oil.



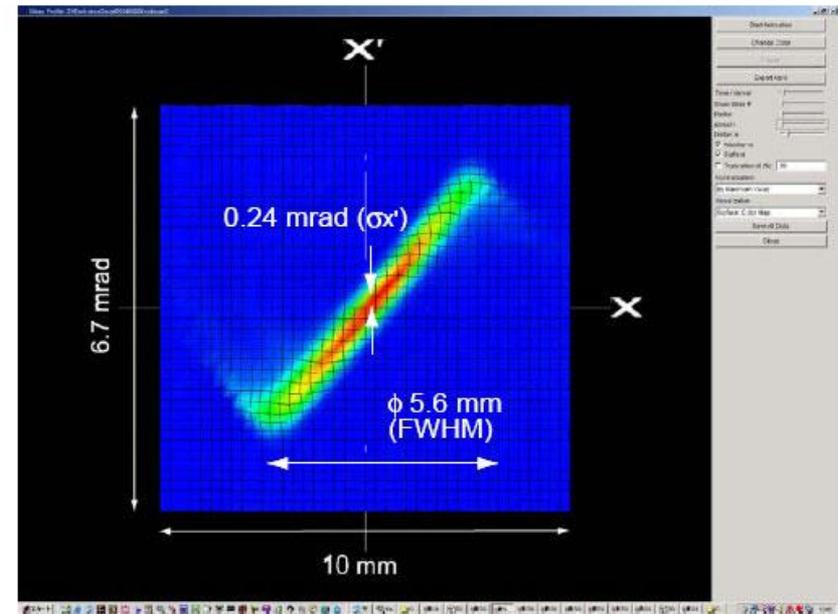
- **No HV breakdown at 500 kV for 4 years, daily operation.**

Measured Emittance at the Gun

Beam Profile



Phase Space Profile



Beam energy	500 keV
Peak current	1 A
Pulse width (FWHM)	$3 \mu\text{s}$
Repetition rate	10 Hz
Normalized emittance (rms, 100% electrons)	1.1π mm mrad
Normalized emittance (rms, 90% electrons)	0.6π mm mrad

SCSS Test Accelerator Performance

- 2006 First lasing at 49 nm
- 2007 Full saturation at 60 nm
- 2008 User operation start

500 kV Pulse electron gun
CeB6 Thermionic cathode
Beam current 1 Amp.

238 MHz
buncher

476 MHz
booster

S-band
buncher

C-band
accelerator

In-vacuum
undulator

E-beam Charge: 0.3 nC
Emittance: 0.7π .mm.mrad
(measured at undulator)
Four C-band accelerators
1.8 m x 4
 $E_{max} = 37$ MV/m
Energy = 250 MeV
In-Vacuum Undulators
Period = 15 mm, $K=1.3$
Two 4.5 m long.

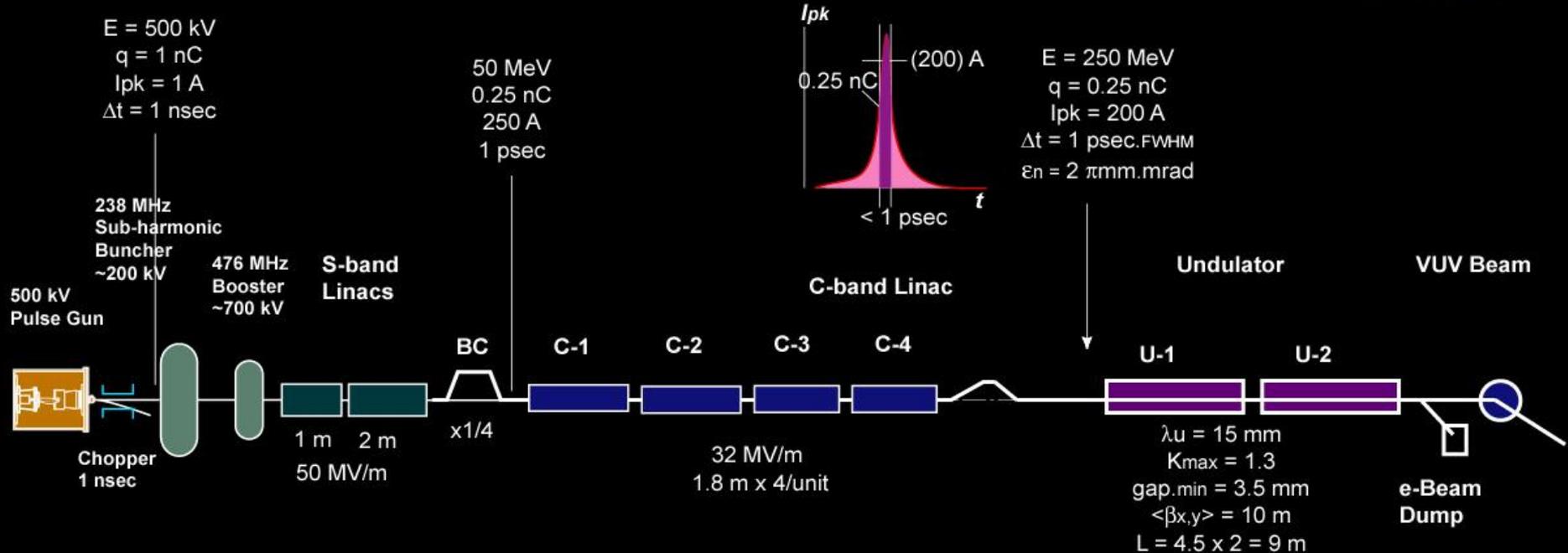
Test Accelerator Configuration

Injector

C-band Main Acc.

Undulator

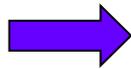
X-ray FEL



1 nsec (chopper)

Velocity Bunching x 100 ~ x 300

1 A, 3 usec gun



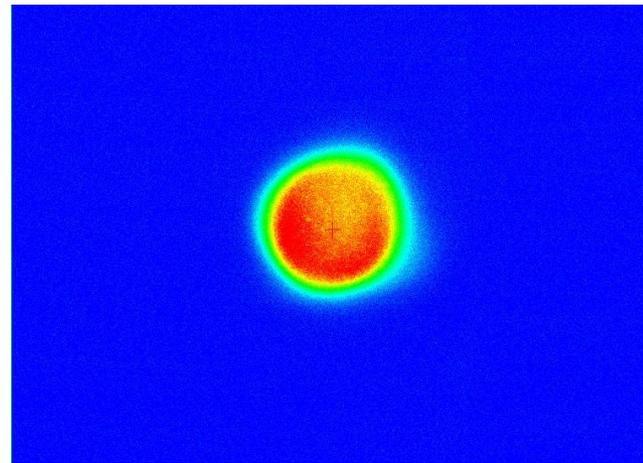
1 A, 1 nsec



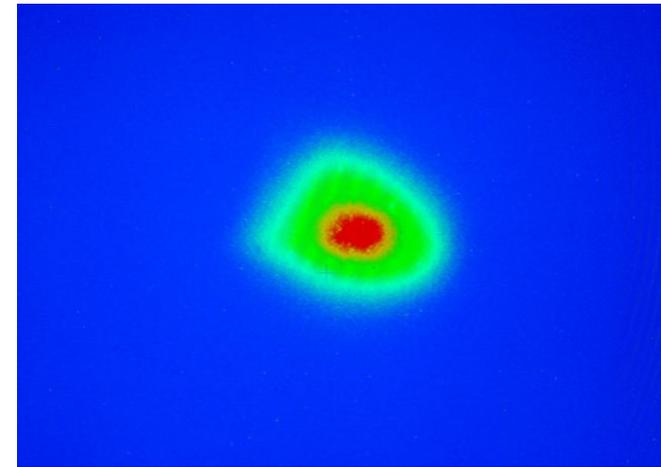
300 ~ 800 A
200 fs ~ 70 fs

CeB₆ Thermionic Gun provides stable beam.

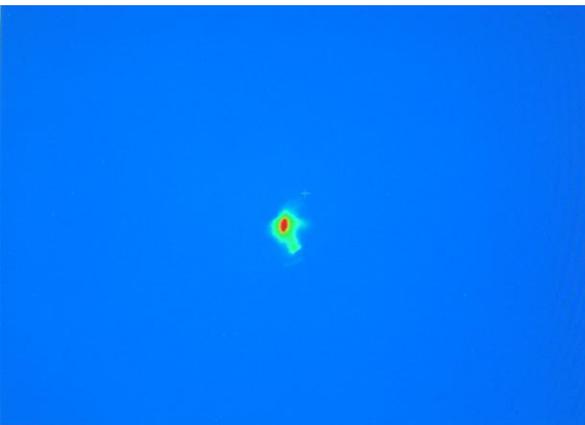
Beam Profile
CCD Image
Scale 10 mm



500 kV Gun



50 MeV Injector Out



250 MeV Compressor

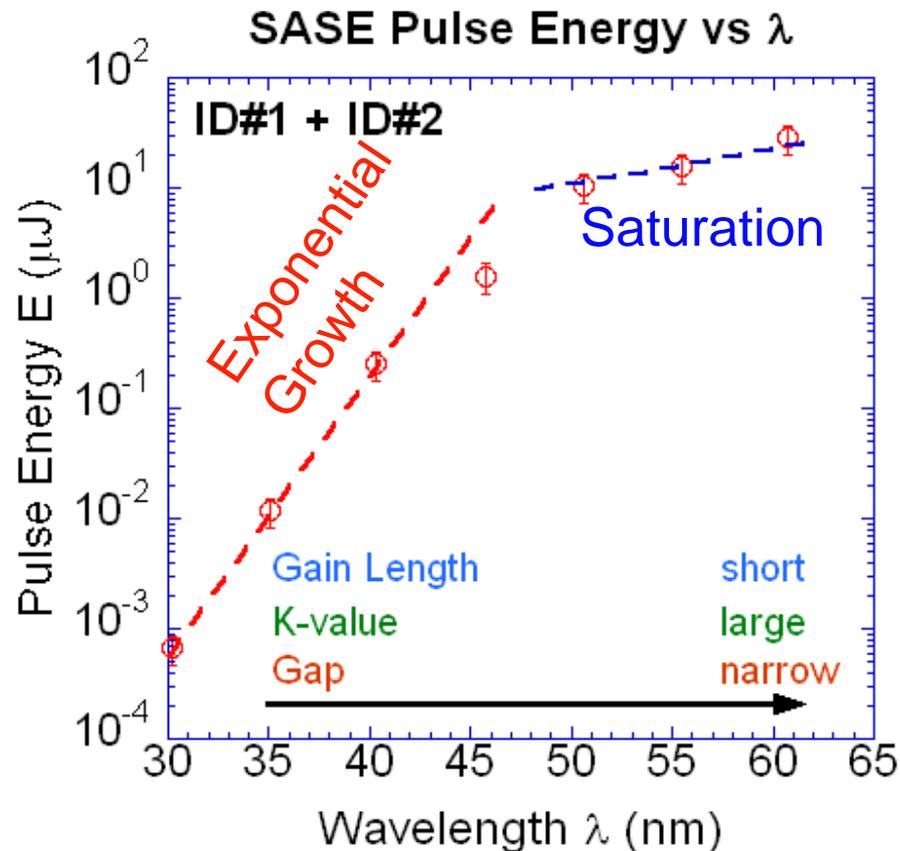


Undulator Input



Undulator Output

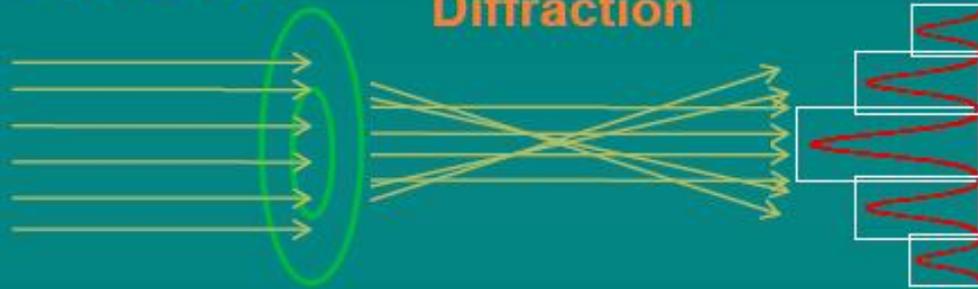
The slice emittance is estimated to be $0.7 \mu\text{m}$ (normalized)



It's laser light at EUV

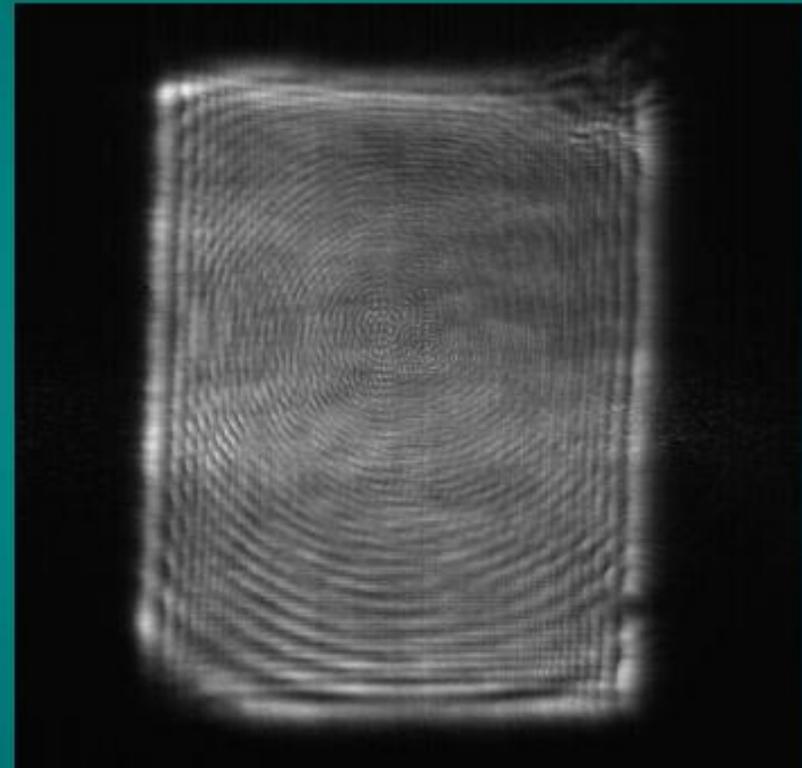
EUV-SASE

Diffraction



Iris: $\phi 10$ mm

CCD image

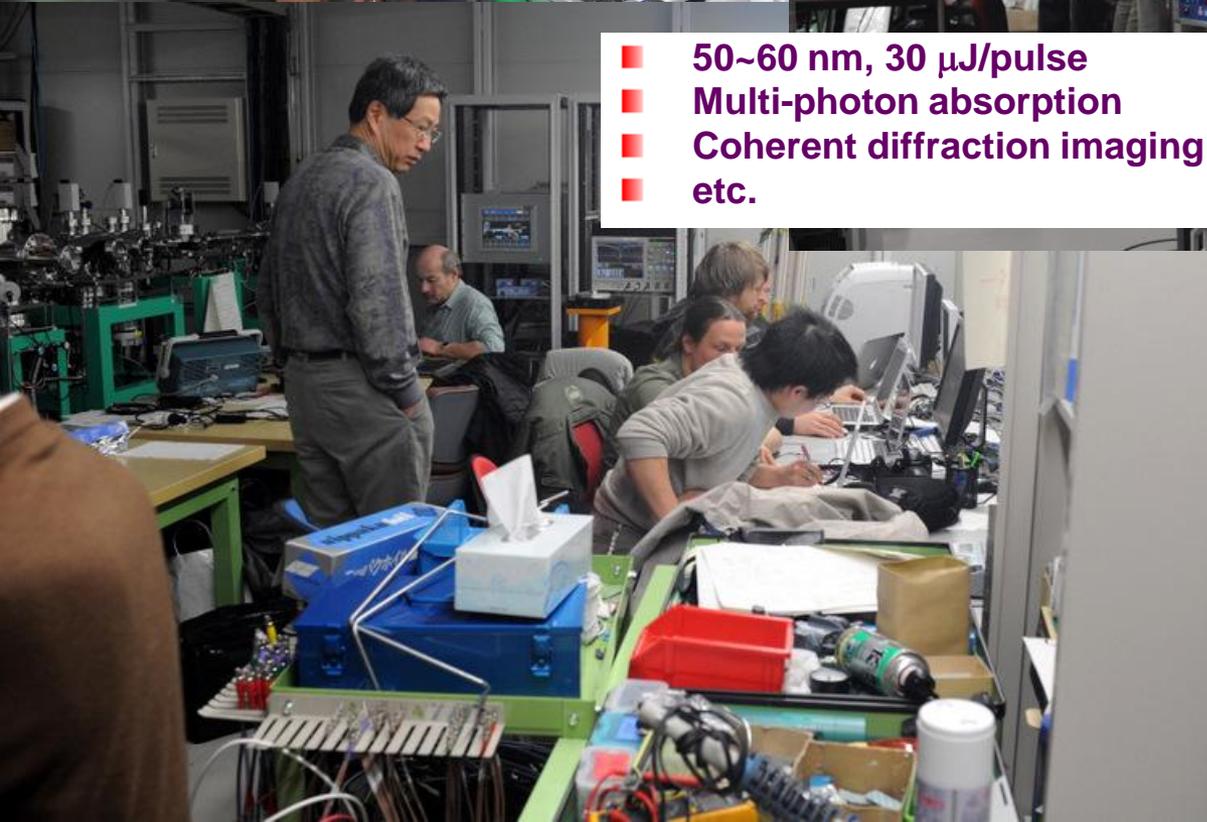


60 nm, courtesy of Nishino.

SCSS Test Accelerator User Run Has been Started in 2008



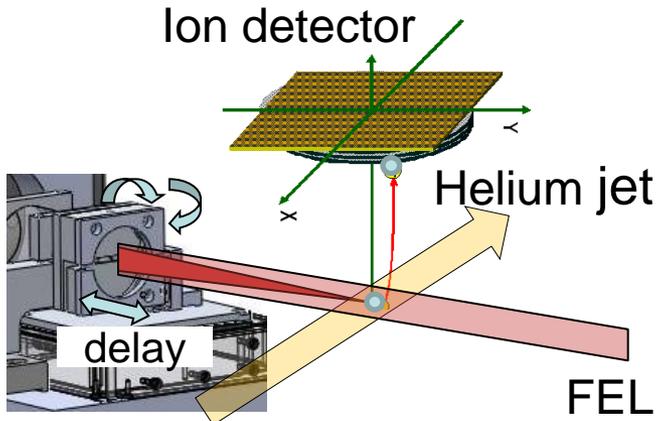
- 50~60 nm, 30 $\mu\text{J}/\text{pulse}$
- Multi-photon absorption
- Coherent diffraction imaging
- etc.



Thermionic cathode & velocity bunching system can generate short bunch with small jitter

- **Bunch length in SCSS < 50 fsec**
(XFEL case it will be < 5 fsec, with additional two chicane by 1/10 compression)
- **Timing jitter is SCSS < 50 fsec**
(XFEL case it will be < 5 fsec+residual)

Split mirror setup



Split focusing mirror

Delay stage: MPI-K, MPQ, CFEL

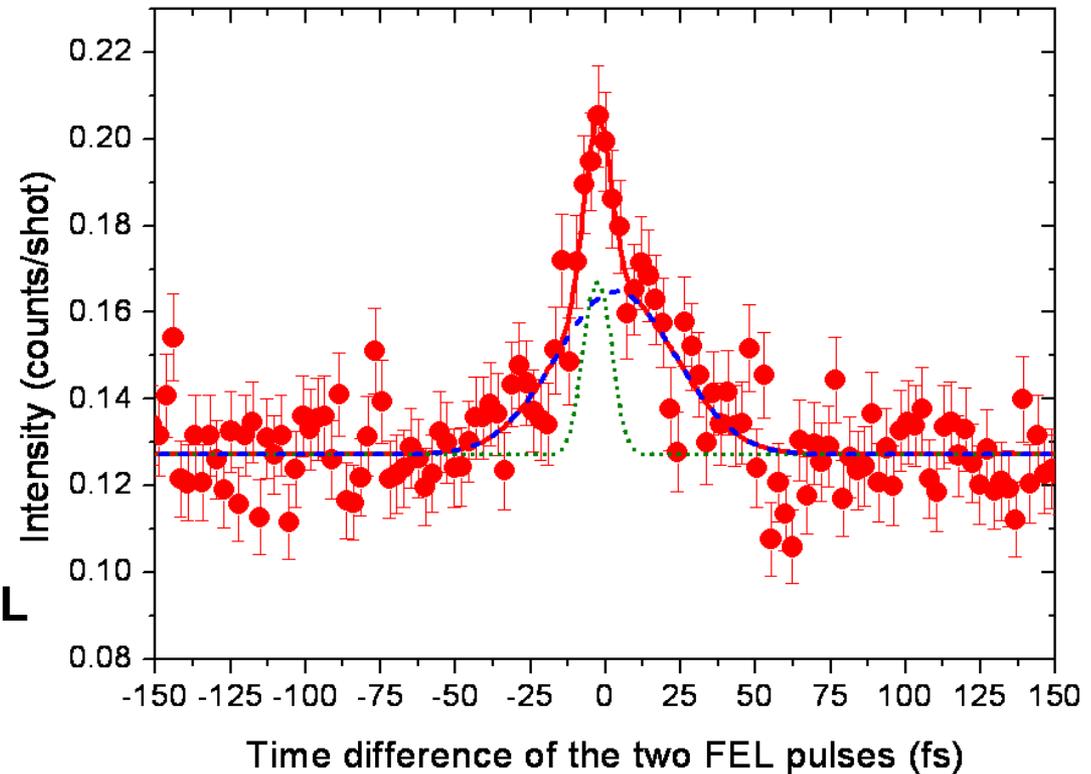
Mirror: LBNL

Detection system: Tohoku U.

From the width of the broad peak,
we can get the FEL pulse duration.

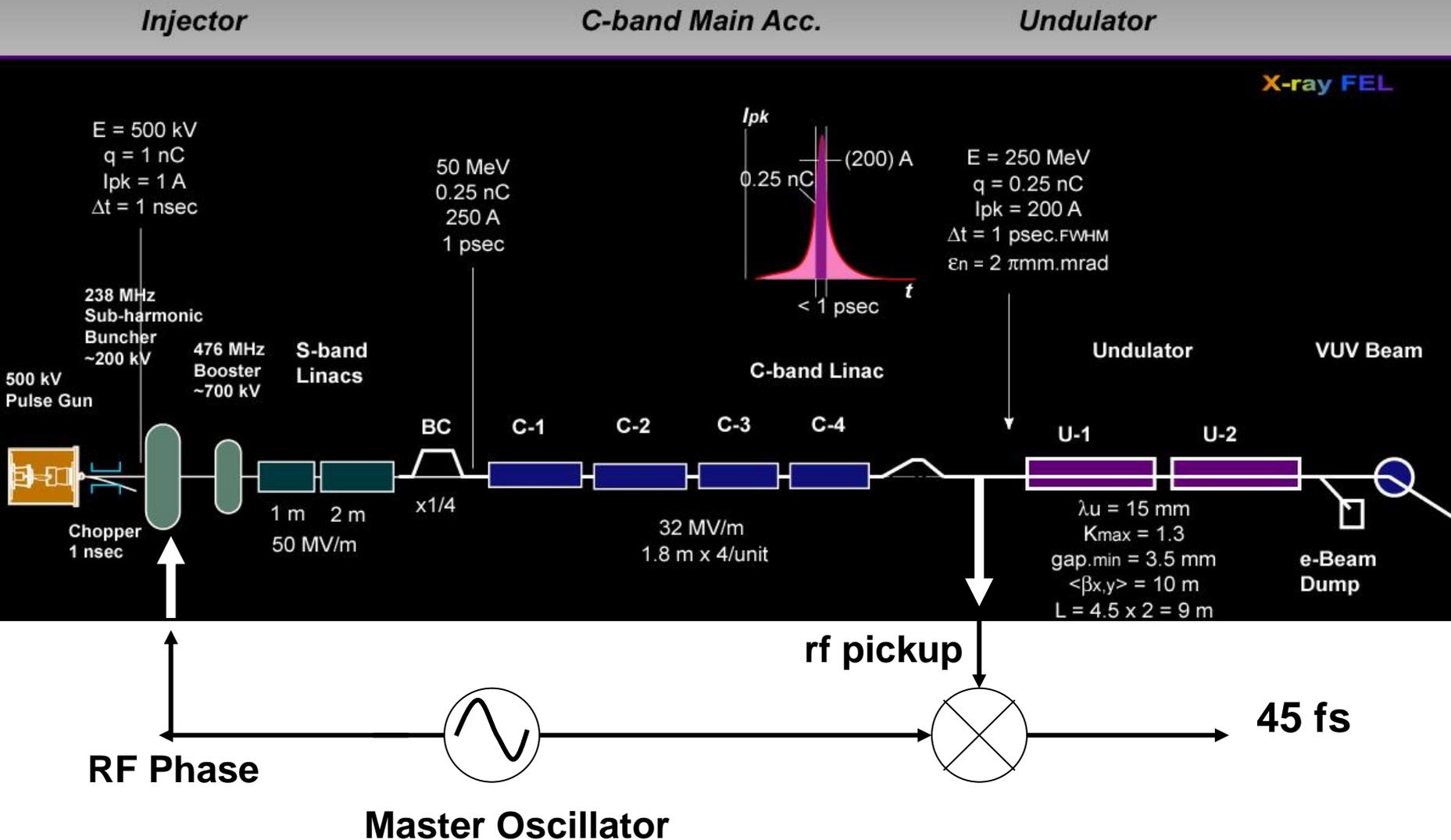
FEL pulse duration ~30 fs

(Pulse duration = FWHM of broad component $1/\sqrt{2}$)



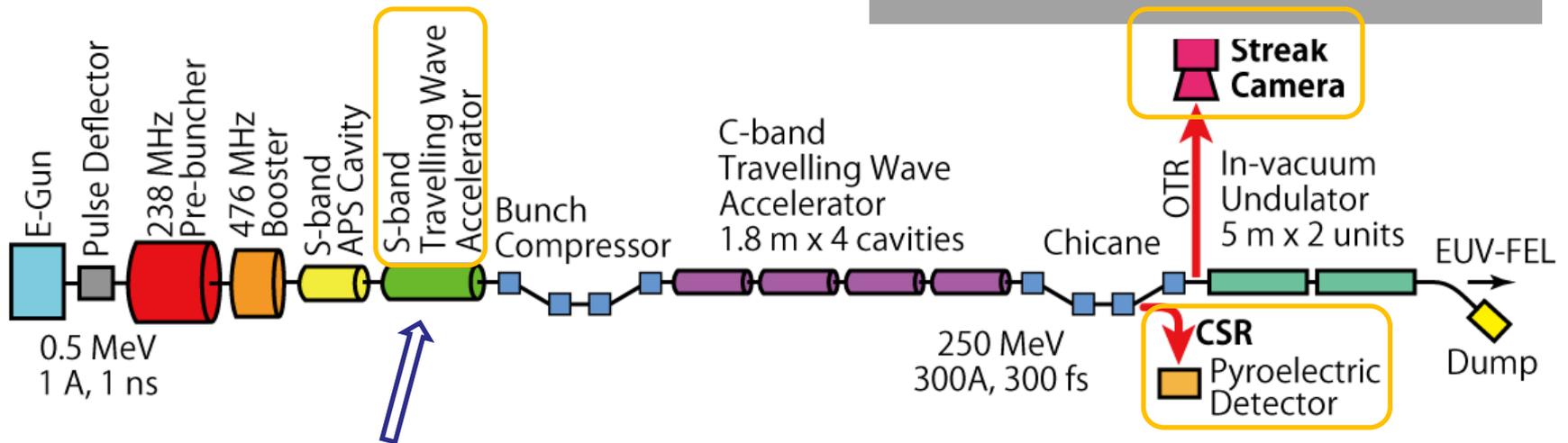
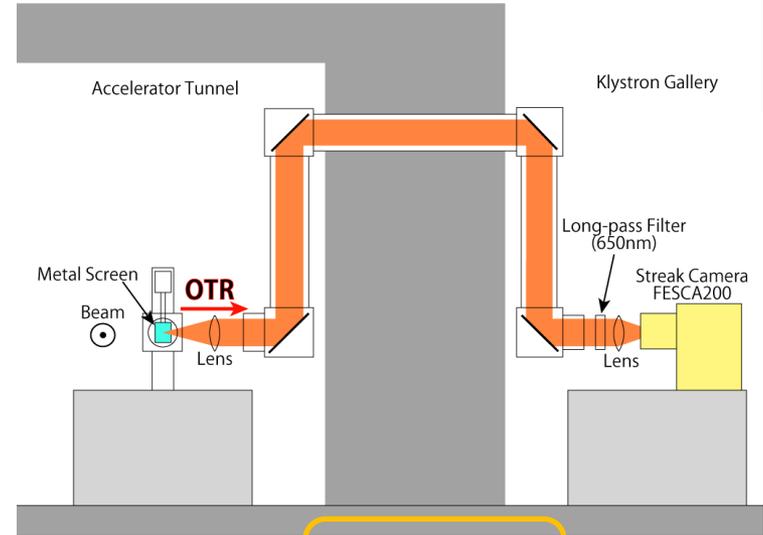
...Kiyoshi Ueda

Timing Jitter



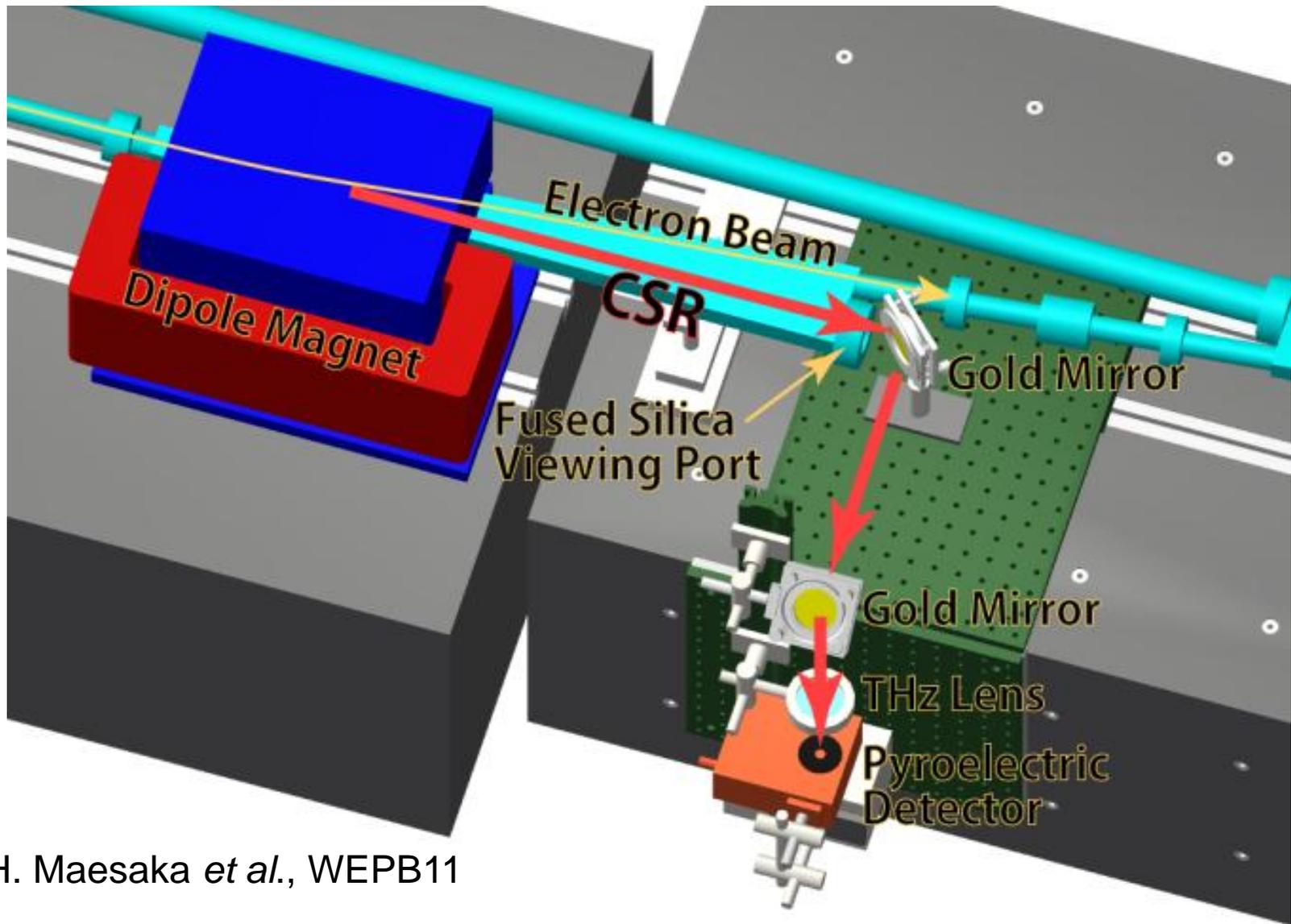
Bunch length was monitored by a CSR monitor and a streak camera at the SCSS test accelerator.

H. Maesaka *et al.*, WEPB11



- Bunch length was changed by the rf phase of the S-band travelling wave accelerator before the bunch compressor.

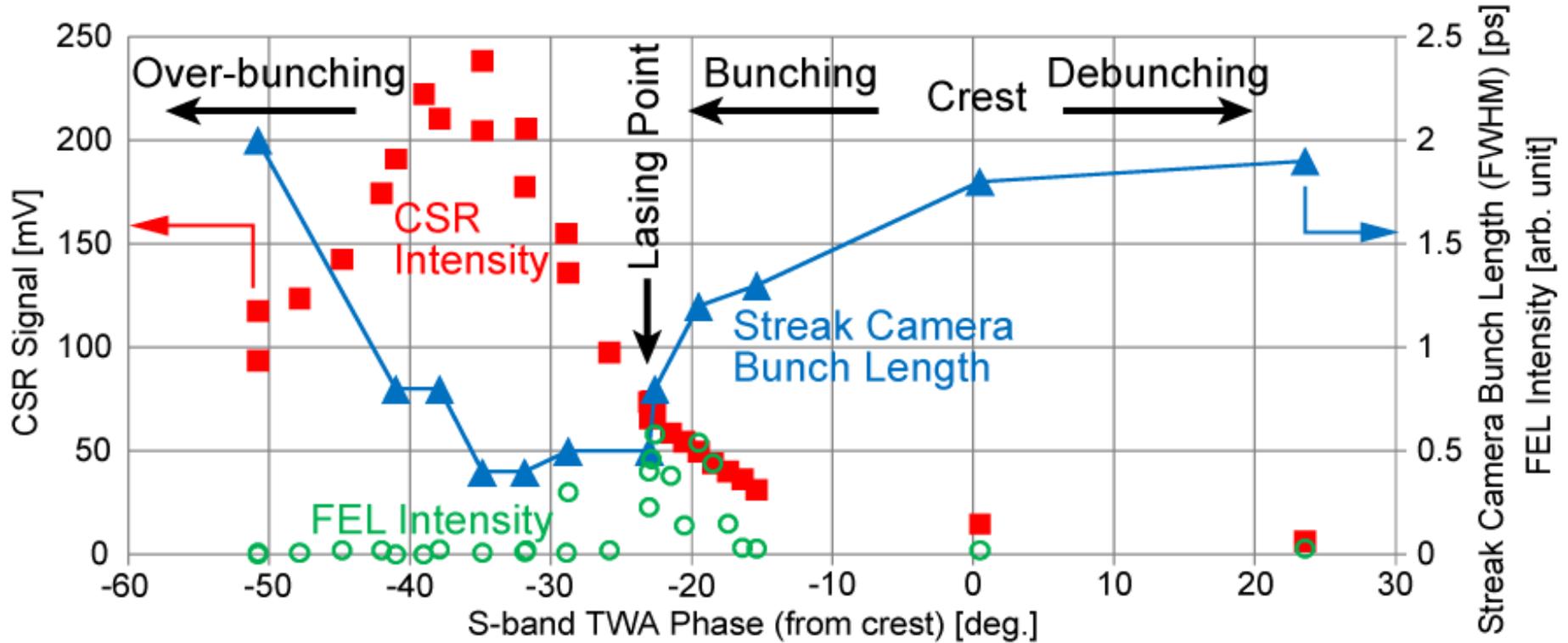
CSR Monitor from 3rd Magnet in chicane at 250 MeV



H. Maesaka *et al.*, WEPB11

Measured CSR intensity and Bunch length by streak camera

H. Maesaka *et al.*, WEPB11



- R56 = 20 mm in bunch compressor at 45 MeV.
- Incoming bunch length = 2 psec (0.6 mm)
- Max energy chirp 0.6 mm/20 mm = 3% at 45 MeV, 0.6% at 250 MeV
- Bunch compression factor $\times 1 \sim \times 5$

Thermionic Gun Produces “Smooth Beam”

- No CSR instability was observed.
- OTR, CSR radiations at chicane magnet are stable, for wide range of bunch compression change.
- → conclusion: there is no density modulation on incoming bunch into chicane compressor
- → thermionic cathode generates smooth beam.
- → **We confirmed no laser heater is required in our system.**

CeB6 Cathode Performance

- We changed cathode twice in SCSS test accelerator.
 - 2005 installed first cathode
 - 2008 January, 1st cathode was changed.
 - 2010 August, 2nd cathode was changed.

- Lifetime > 10,000 hours (~2 years)

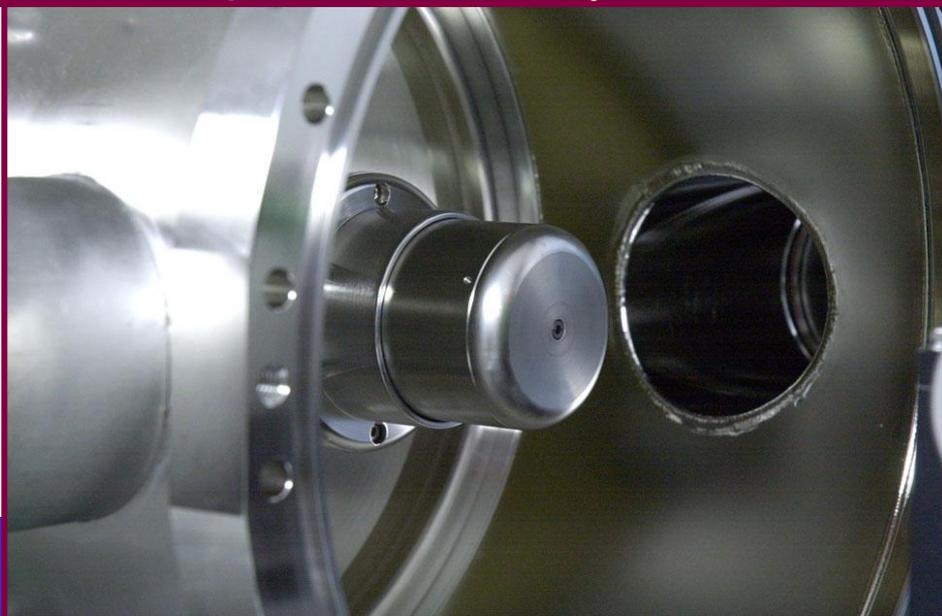
- At end of lifetime, emission decreased, but emittans is OK.

2008/01/28

First experience, but team did nice work.



We replaced CeB6 crystal in SCSS accelerator, after 20,000 hour operation.



Anode flange had color change.

CeB6 cathode after 20,000 hour use.



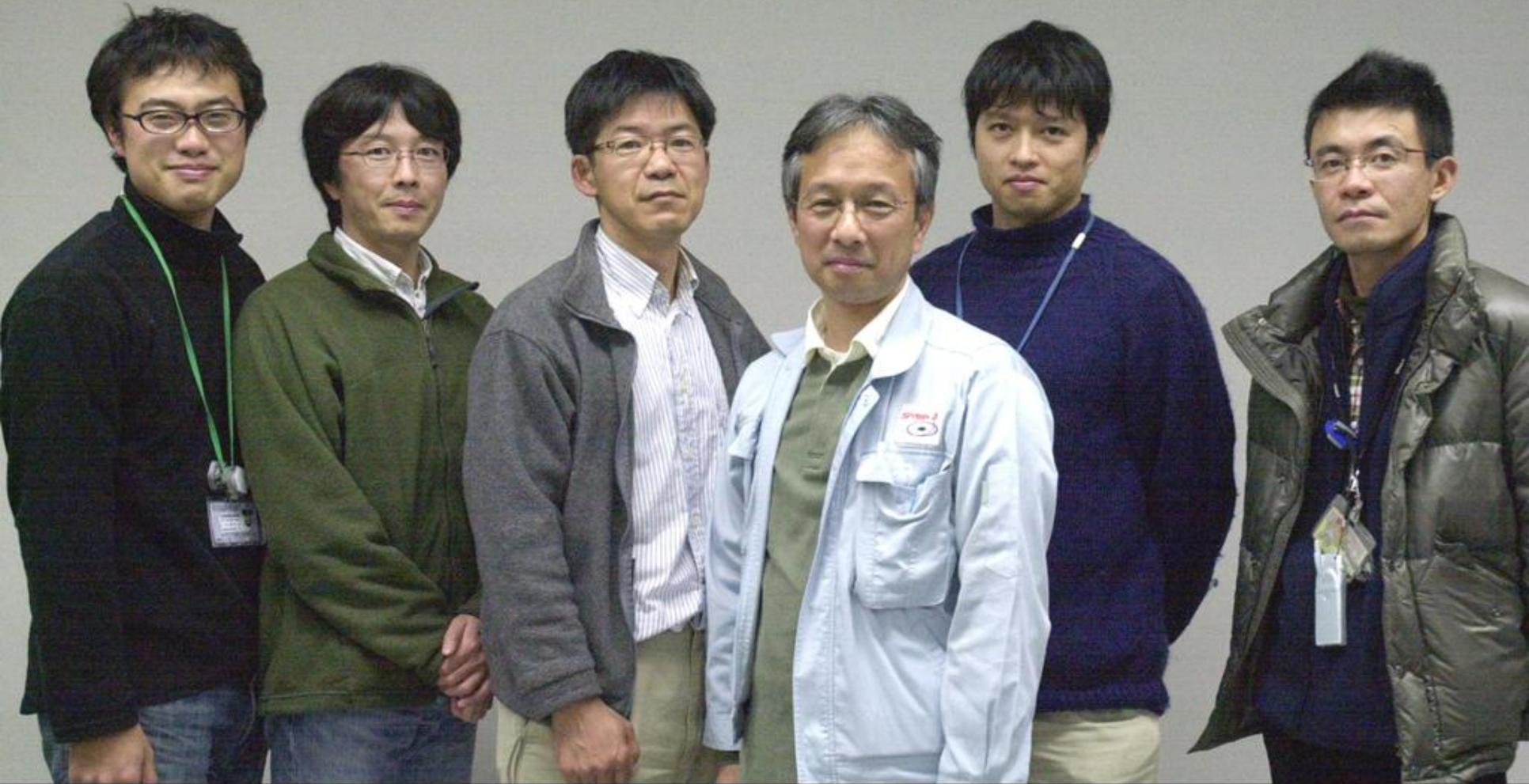
It was found the cathode surface became concave of 0.2 mm deep from the initial flat surface. It corresponds to evaporation speed of 10 nm/hour ($10 \text{ nm/h} \times 20,000 \text{ h} = 200 \text{ micron-meter}$) Concave geometry made beam slightly focusing, but did not break emittance. Electron microscope study showed (1) Surface is fairly smooth, (2) covered by carbon contamination (lowered electron emission).

Electron Gun and Injector



1. **CeB6 Cathode: emission was tested.... OK.**
2. **Gun: 500 kV operation in bunker....OK**
3. **238 MHz, 476 MHz, L-correction, C-correction cavities and RF....OK**
4. **L-band RF is OK, but APS cavity is under fabrication. ...Waiting**

Otake's Team: LLRF, Beam Diagnostics



Matsubara

Hosoda

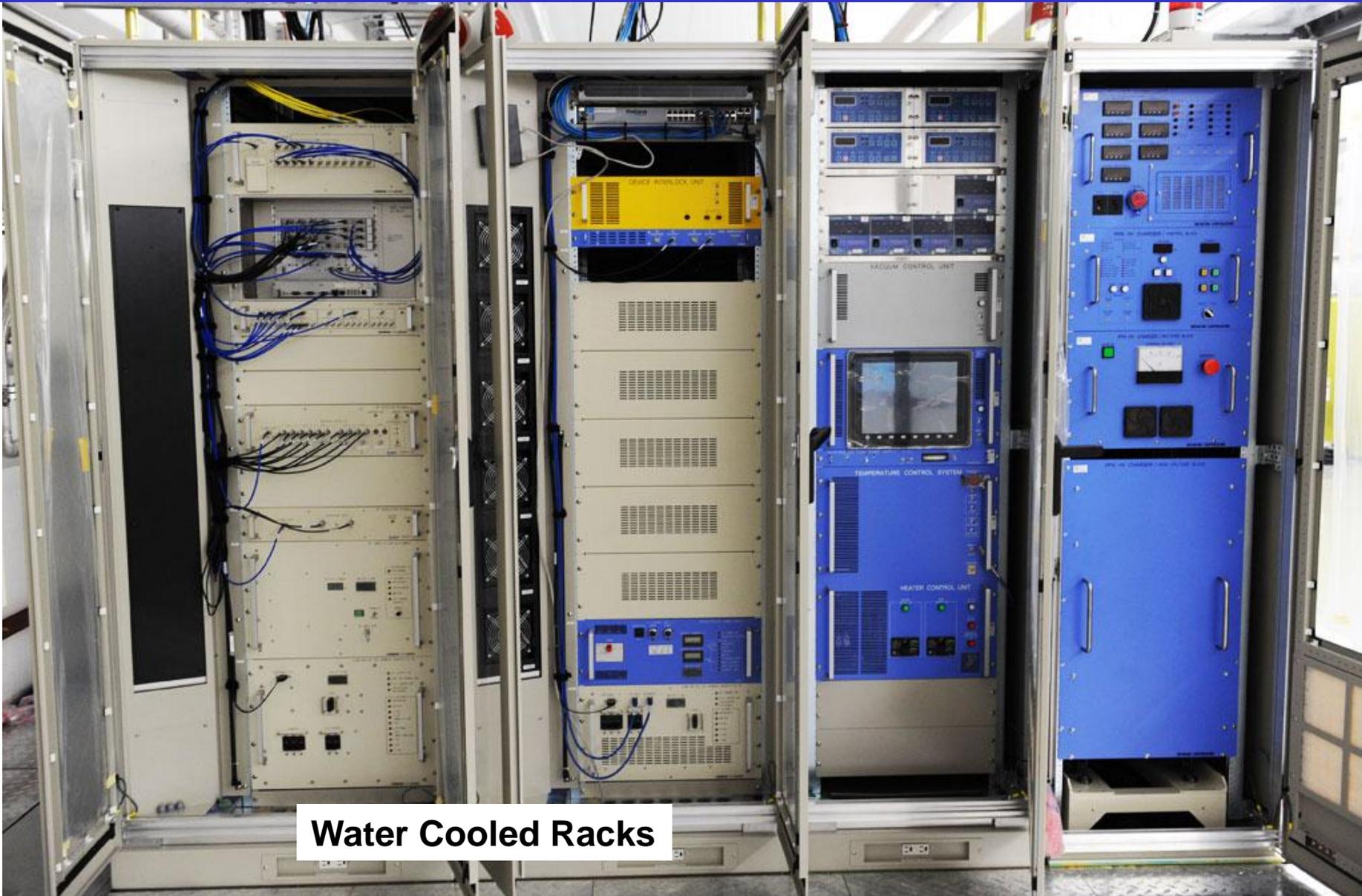
Oshima

Otake

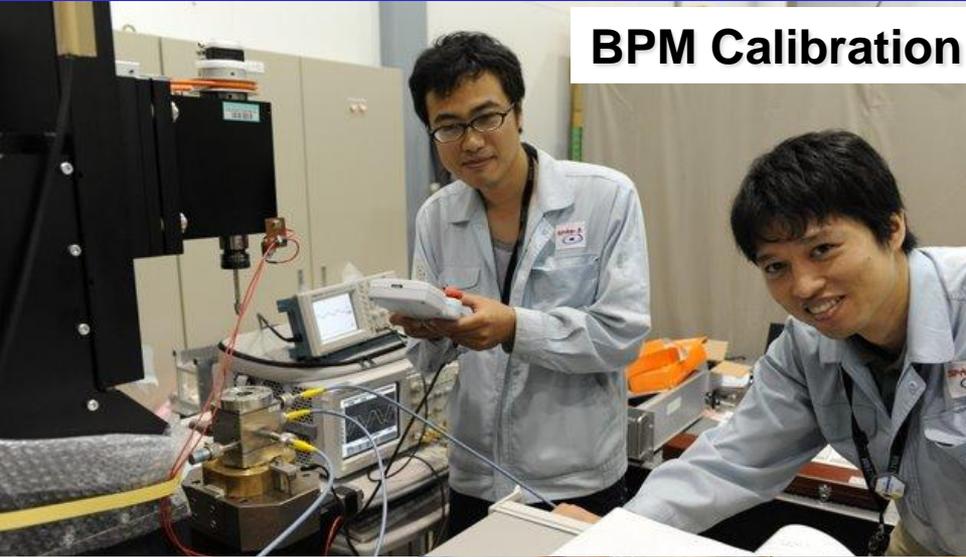
Maesaka

Inoue

MADOCA Controls, LLRF, Temp Feedback, PFN Charger



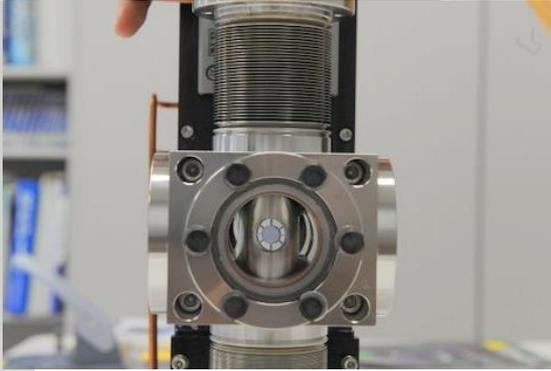
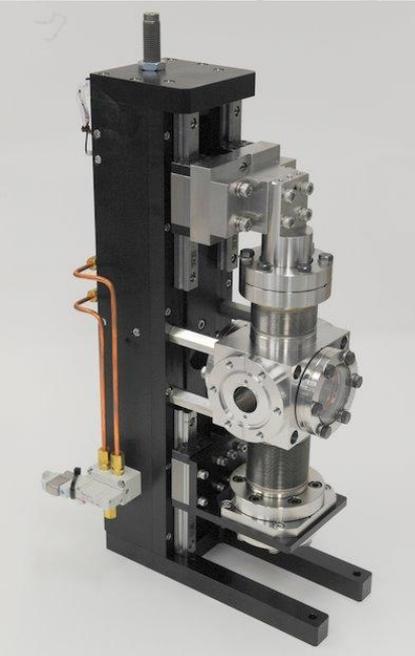
Water Cooled Racks



BPM Calibration



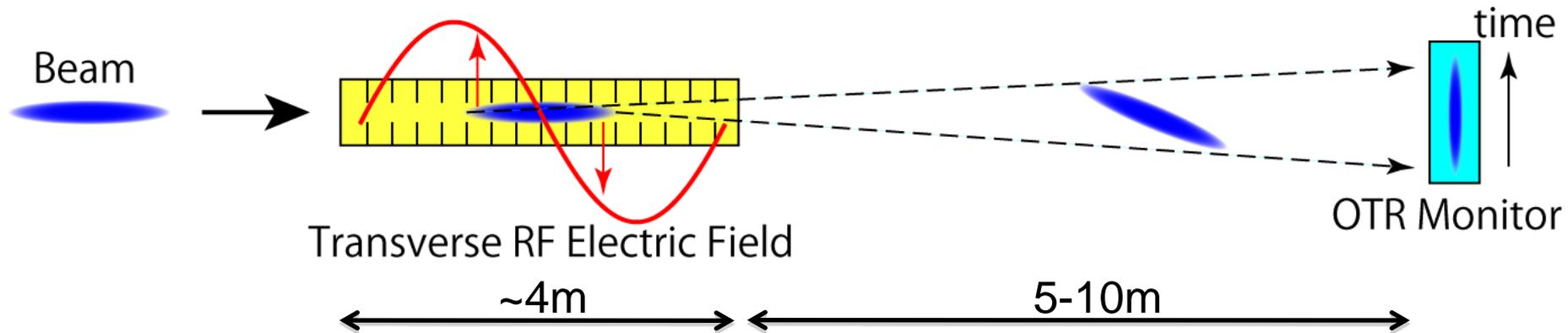
Cavity BPMs
0.2 μm resolution was confirmed with beam



OTR Screen Monitor

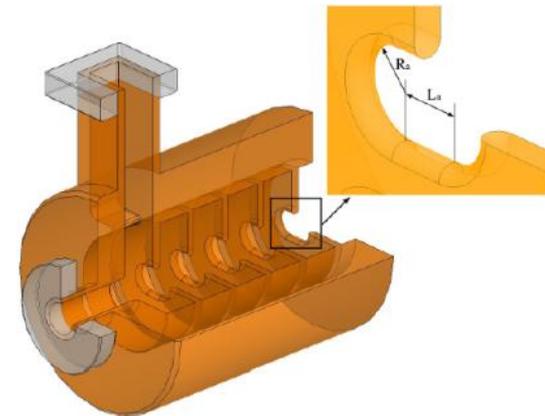


C-Band RF Deflector has been developed

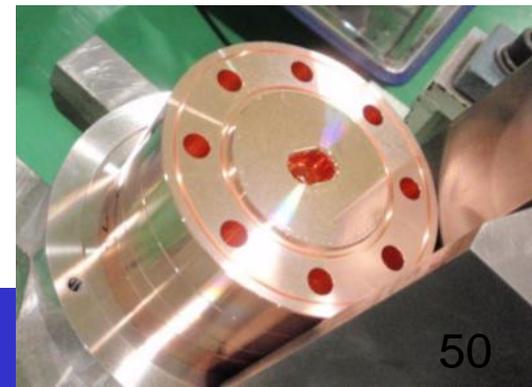


■ RAIDEN-Cavity

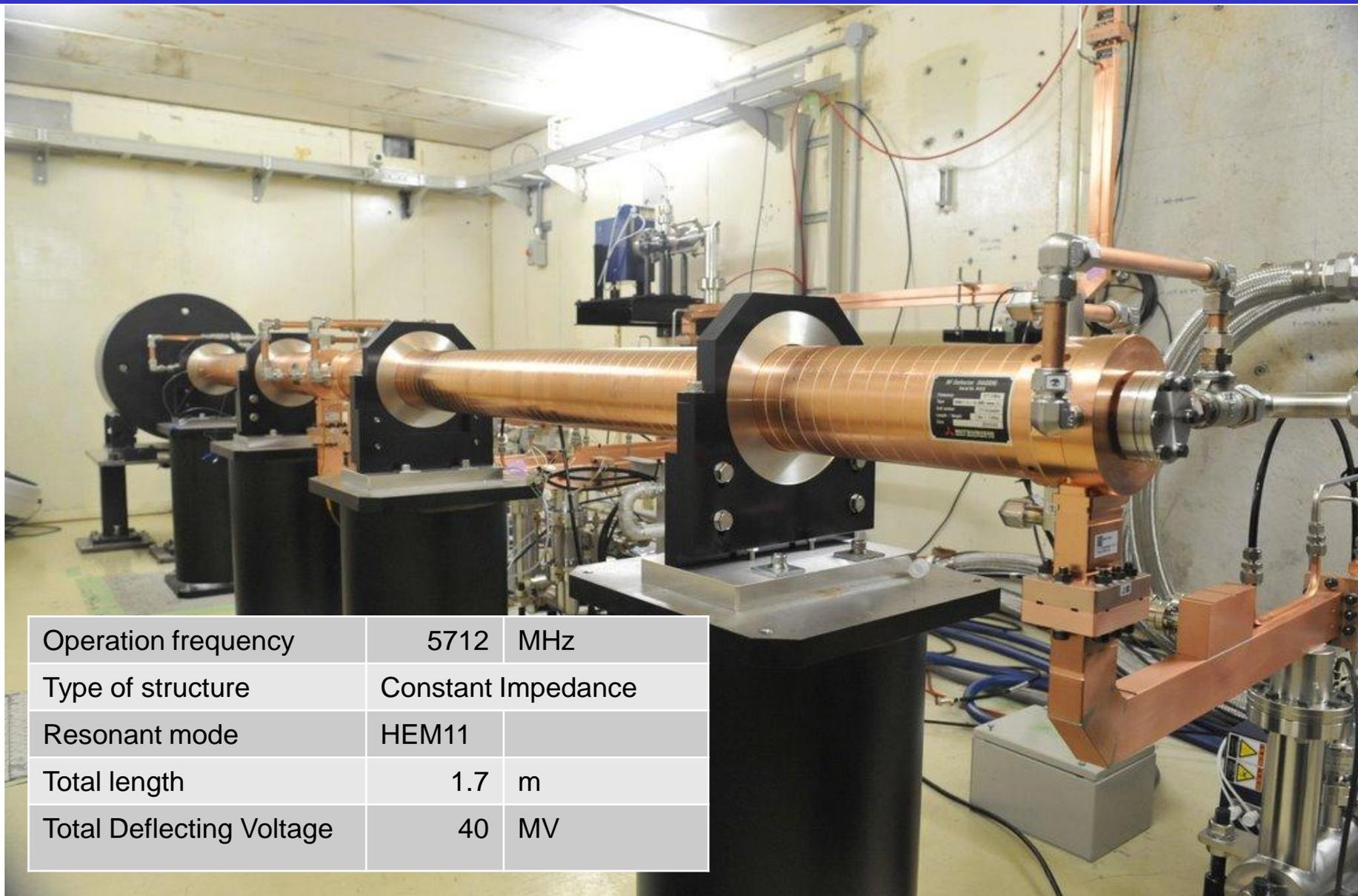
- Race-track iris provide xy-mode separation
- Backward HEM₁₁- $5\pi/6$ mode



H. Ego, Y. Otake *et al.*, "Design of the Transverse C-band Deflecting Structure for Measurement of Bunch Length in X-FEL", Proceedings of EPAC'08.



Two RAIDEN structures are under high power testing.



Operation frequency	5712	MHz
Type of structure	Constant Impedance	
Resonant mode	HEM11	
Total length	1.7	m
Total Deflecting Voltage	40	MV

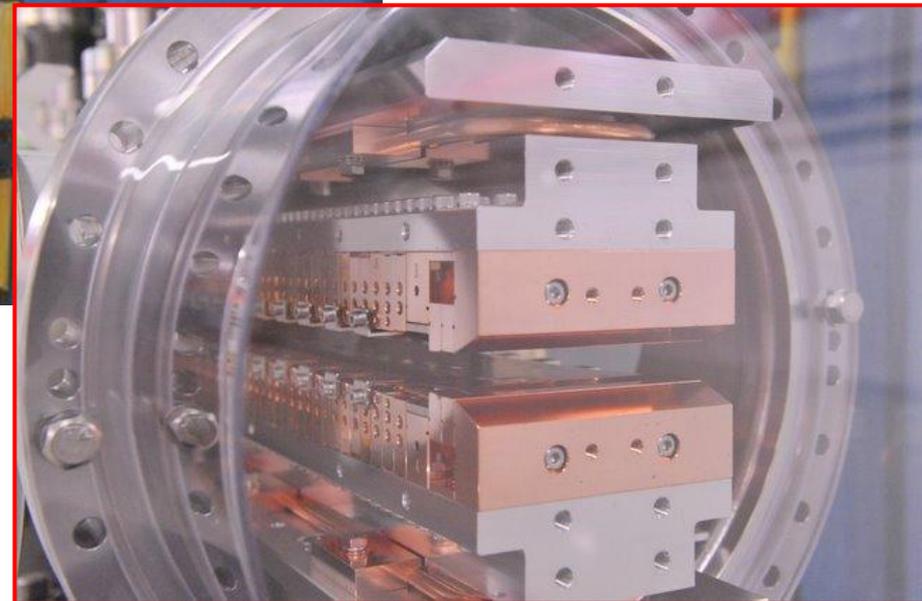
All undulators (18) have been installed in August



Undulator for XFEL/SPring-8

Undulator Type	In-Vacuum Planer Undulator	
Active Length	5 m	
Undulator Period	18 mm	
Magnetic Circuit	Hybrid (NdFeB+Permendur)	
Peak Field	Maximum	1.31 T
	Nominal	1.13 T
K	Maximum	2.2
	Nominal	1.9
Gap	Minimum	3.5 mm
	Nominal	4.5 mm
Maximum Attractive Force	~ 6 ton	

In Vacuum Undulator



Undulator for XFEL/SPring-8

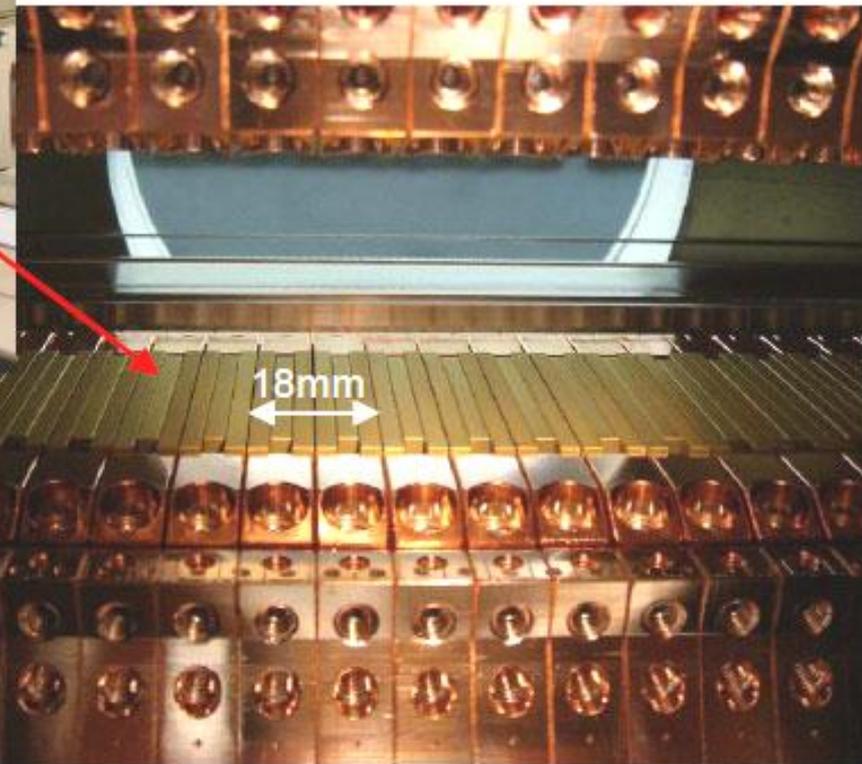


Outlook of 5 m long in-vacuum undulator for X-ray FEL.

NeFeB magnet array,
undulator period is 18 mm.

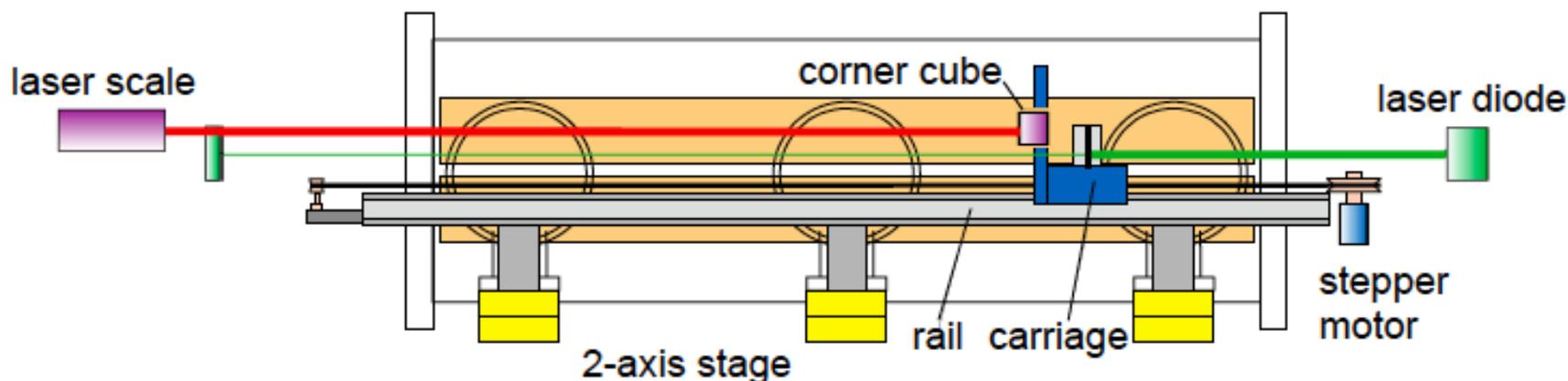


The undulator for XFEL is made by the team guided by H. Kitamura and T. Tanaka



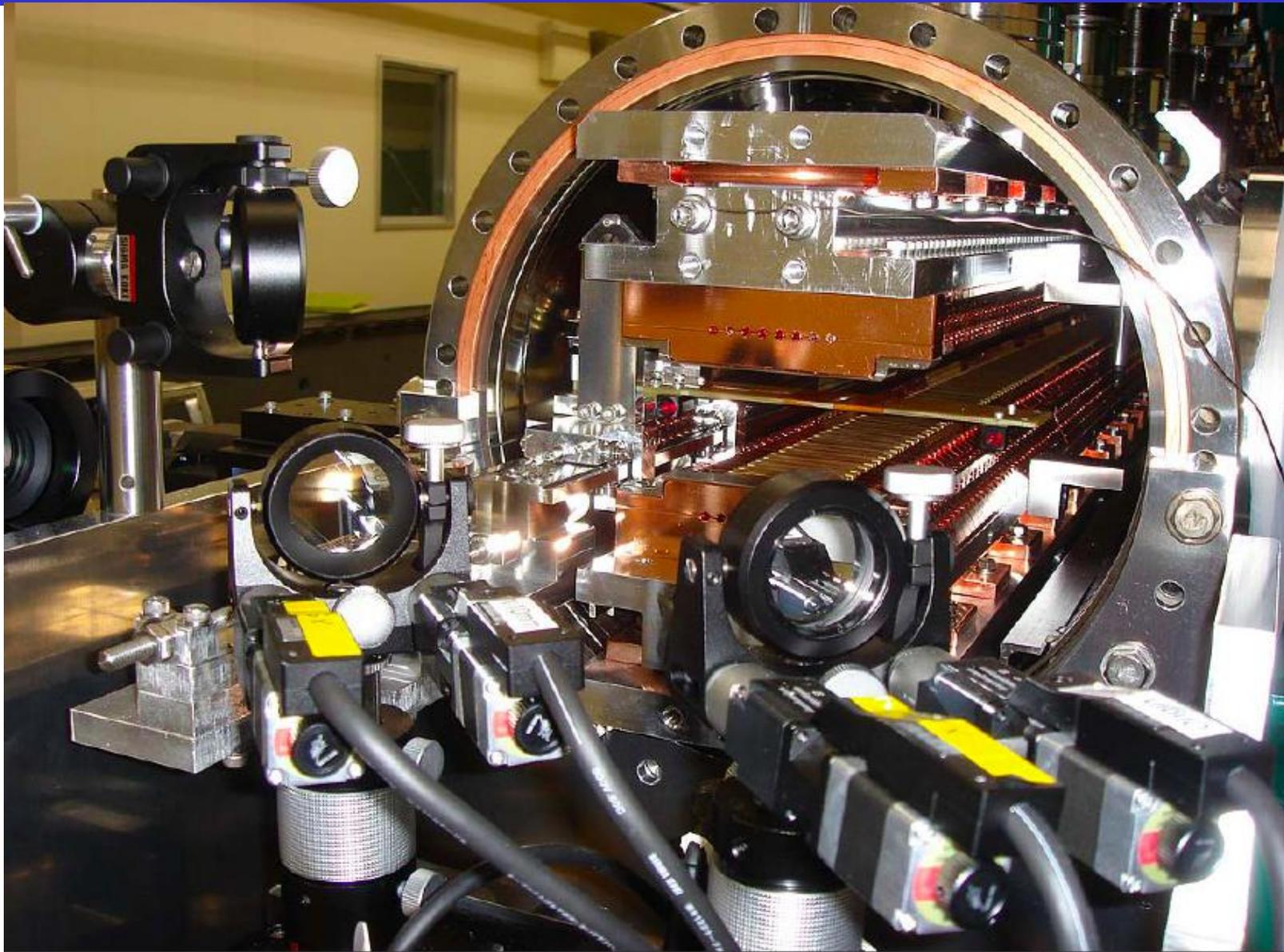
SAFALI Field Measurement System

- SAFALI: Self-Aligned Field Analyzer with Laser Instrumentation
 - Simple mover of hole probe.
 - fit within vacuum chamber.
 - Laser beam guide for xy-displacement, and position feedback on guide rail.
 - Laser distance meter for z-location.



Tuning magnet and gap on site, including earth magnetic field effect.

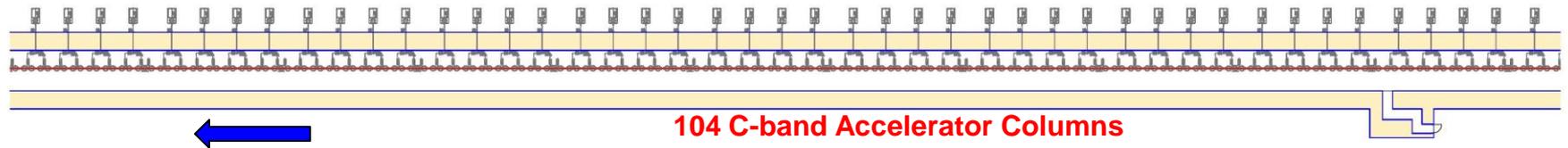
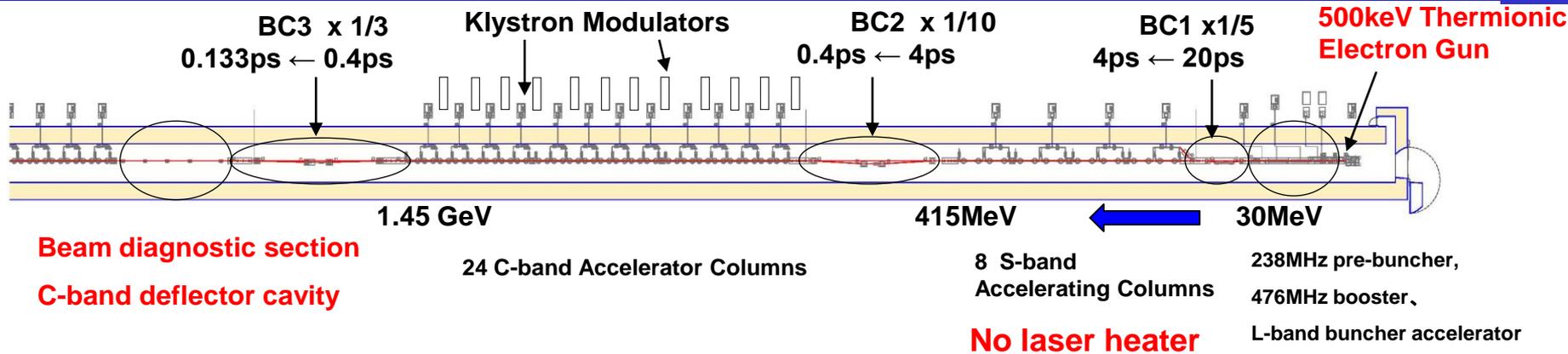
SAFALI in-situ field measurement



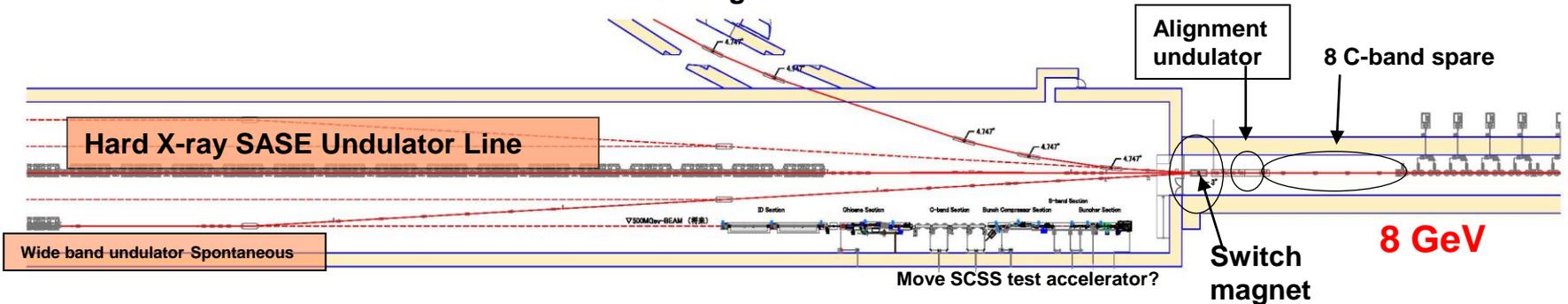
Summary & Schedule

- 2010 Sept. Complete installation.
- 2010 Oct. ~ 2011 Feb. High power processing.
- 2011 March First beam to the undulator.
- 2011 April - July Beam commissioning, and the first FEL Lasing?

XFEL Machine Configuration



to SPring-8



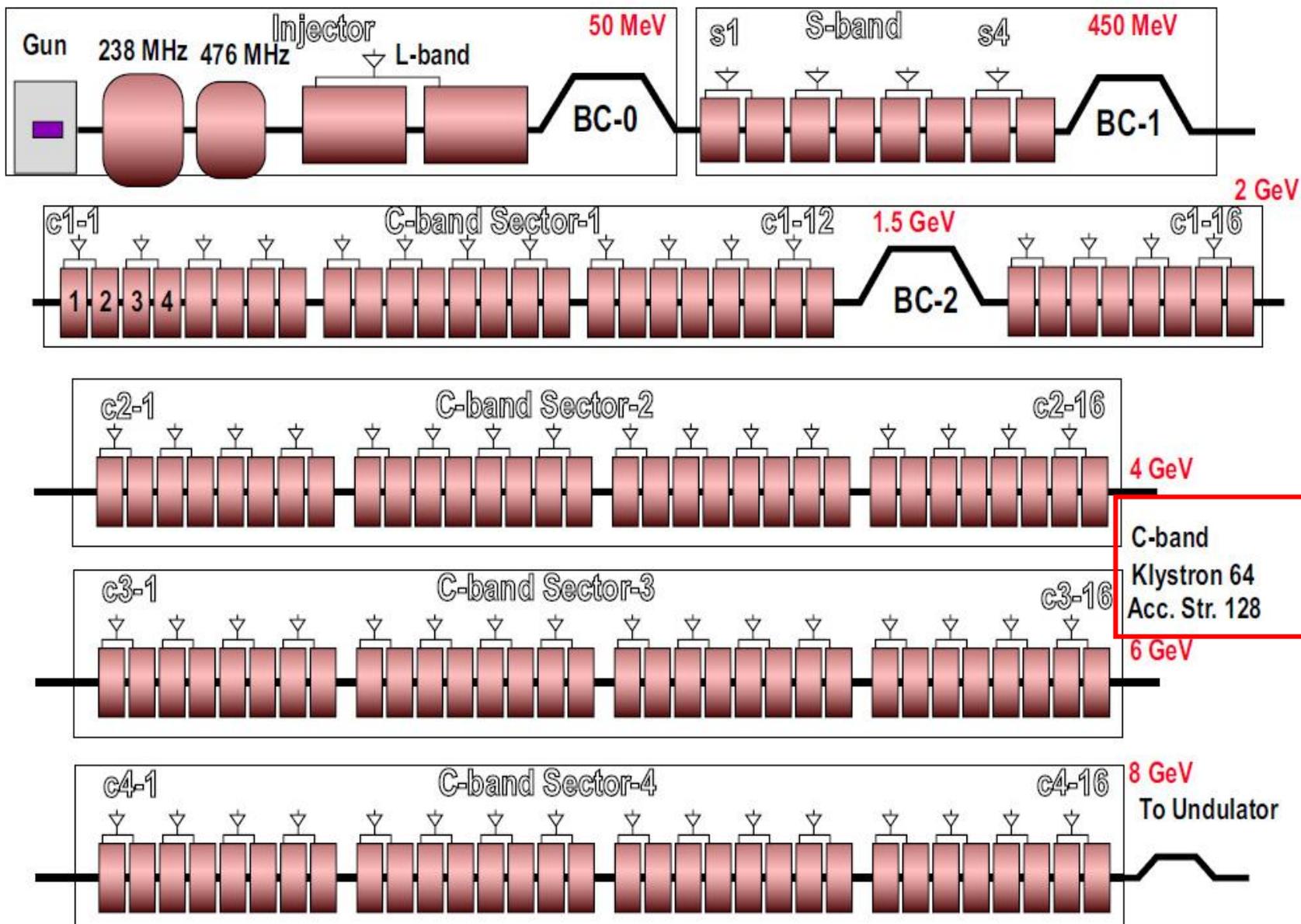
Experiment-stations

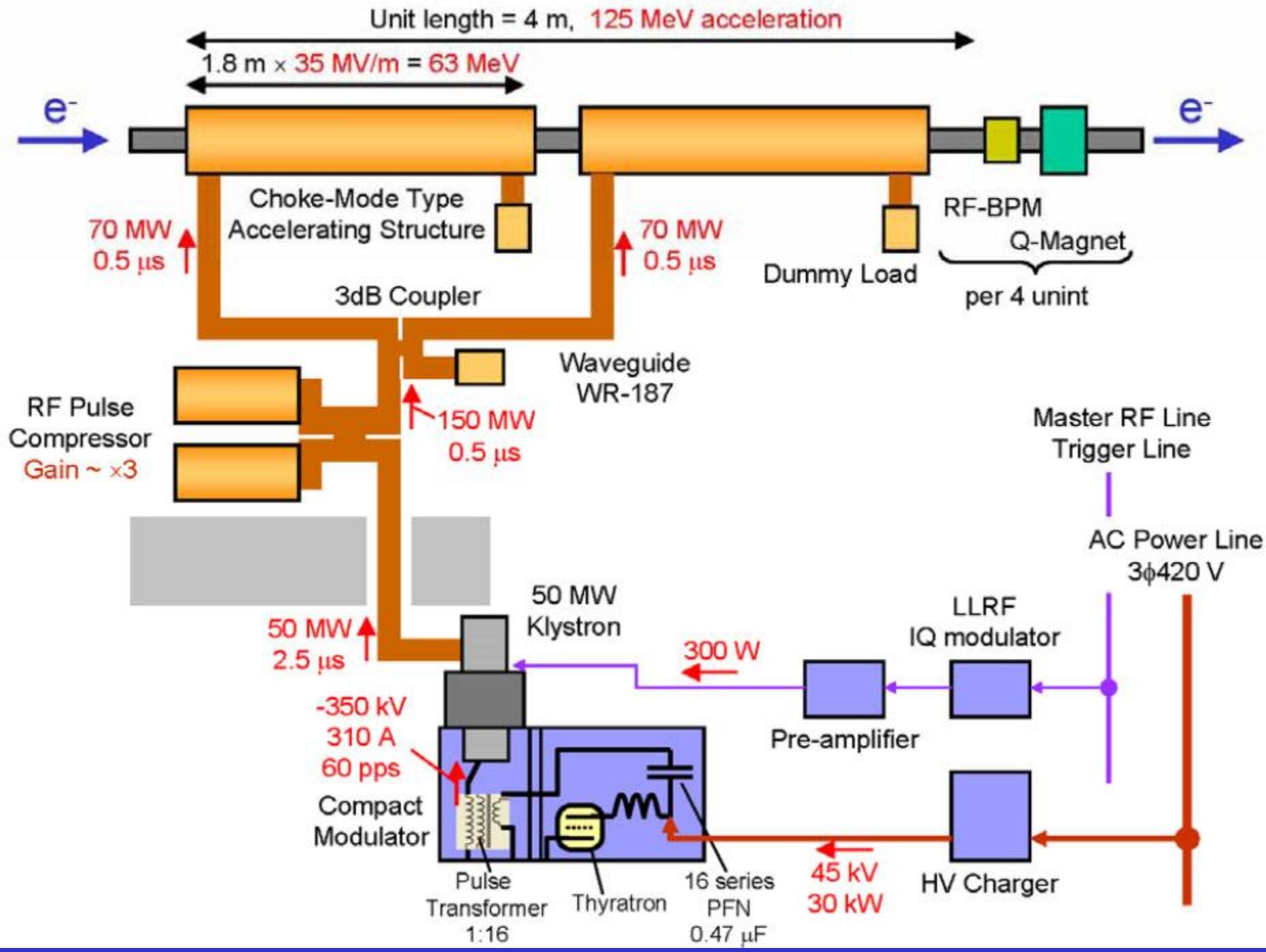
X-ray Front-end

8GeV Beam Dump

- BL-5
- BL-4
- BL-3
- BL-2
- BL-1

RF Acceleration System in XFEL/SPring-8





C-band Klystron Development

Under life test since April 1999



Traveling-wave
output structure

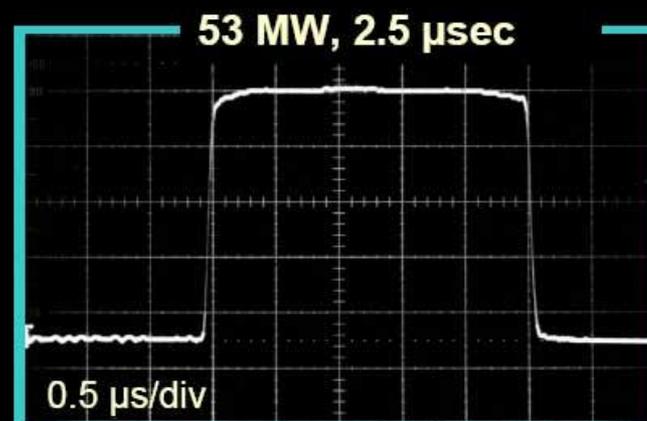
Solenoid
Focus (4.6kW)

1.5 μ P

Dispenser
Cathode
(D74.5mm, 6.3A/cm²)

53 MW, 2.5 μ sec, 50 pps, 47%

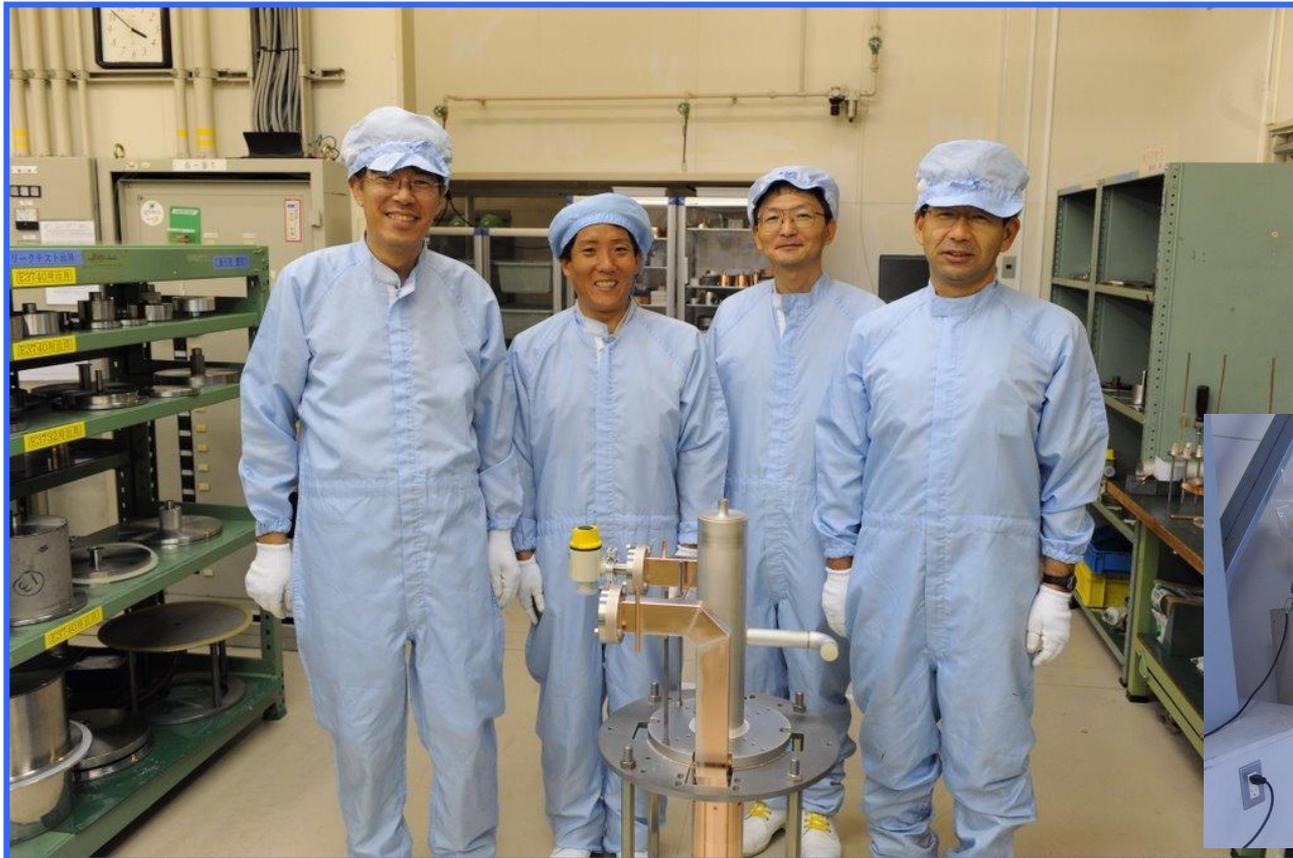
TOSHIBA E3746 No.3



Mass Production of Klystrons at TOSHIBA

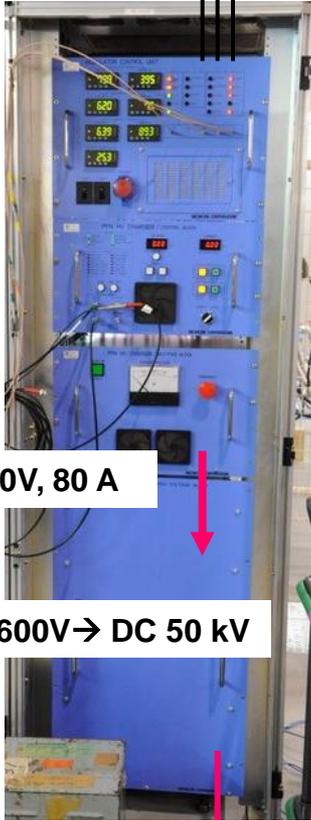
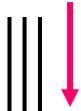
- 64 C-band klystron
- 4 S-band klystron
- 1 L-band klystron

C-band Klystron
5712 MHz, 50 MW
4 μ sec, 60 pps
45 % efficiency
Three-cell traveling wave output



C-band System Configuration

400 V, 3 ϕ



600V, 80 A



DC 600V \rightarrow DC 50 kV



Highly stable
PFN charger
< 100 PPMp-p

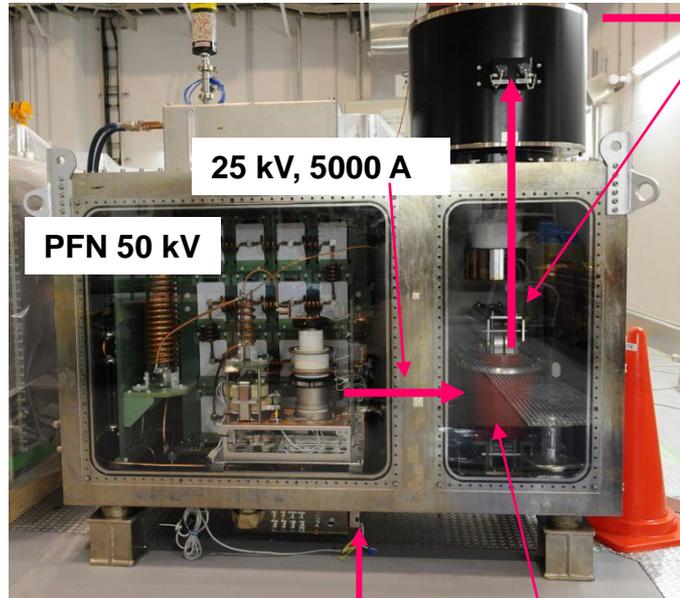
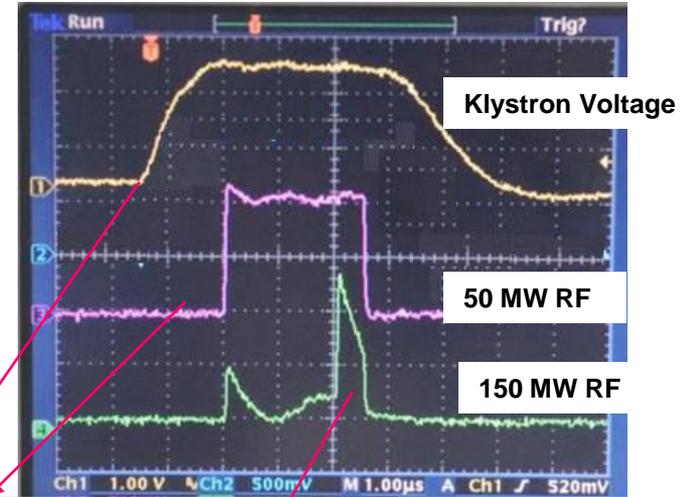


Klystron Modulator



**C-band
Klystron**

50 MW, 3 usec
RF 5712MHz

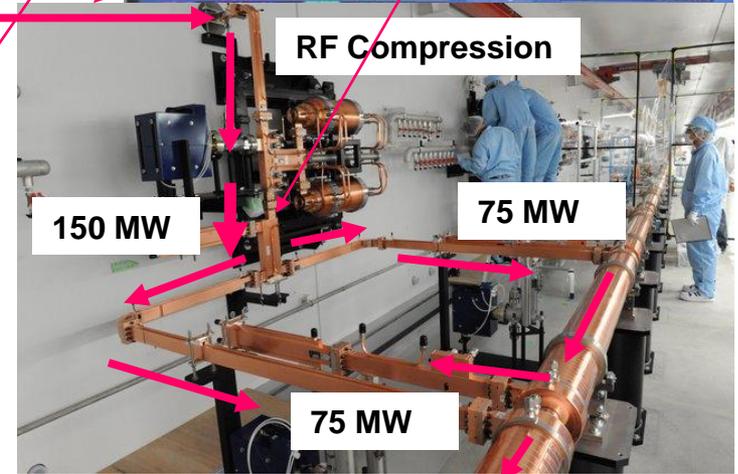


25 kV, 5000 A

PFN 50 kV

50 kV, 1 A

25 kV \rightarrow 350 kV



RF Compression

150 MW

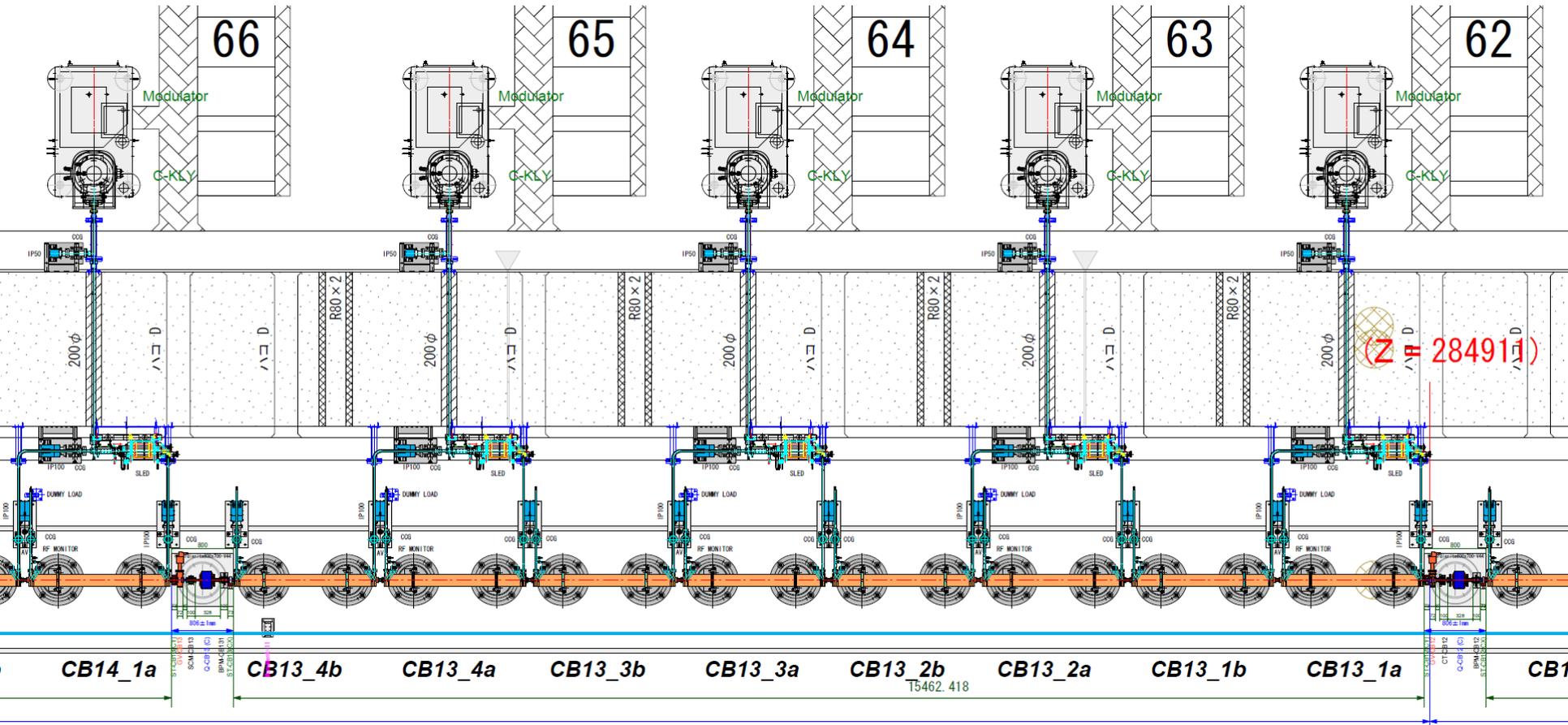
75 MW

75 MW

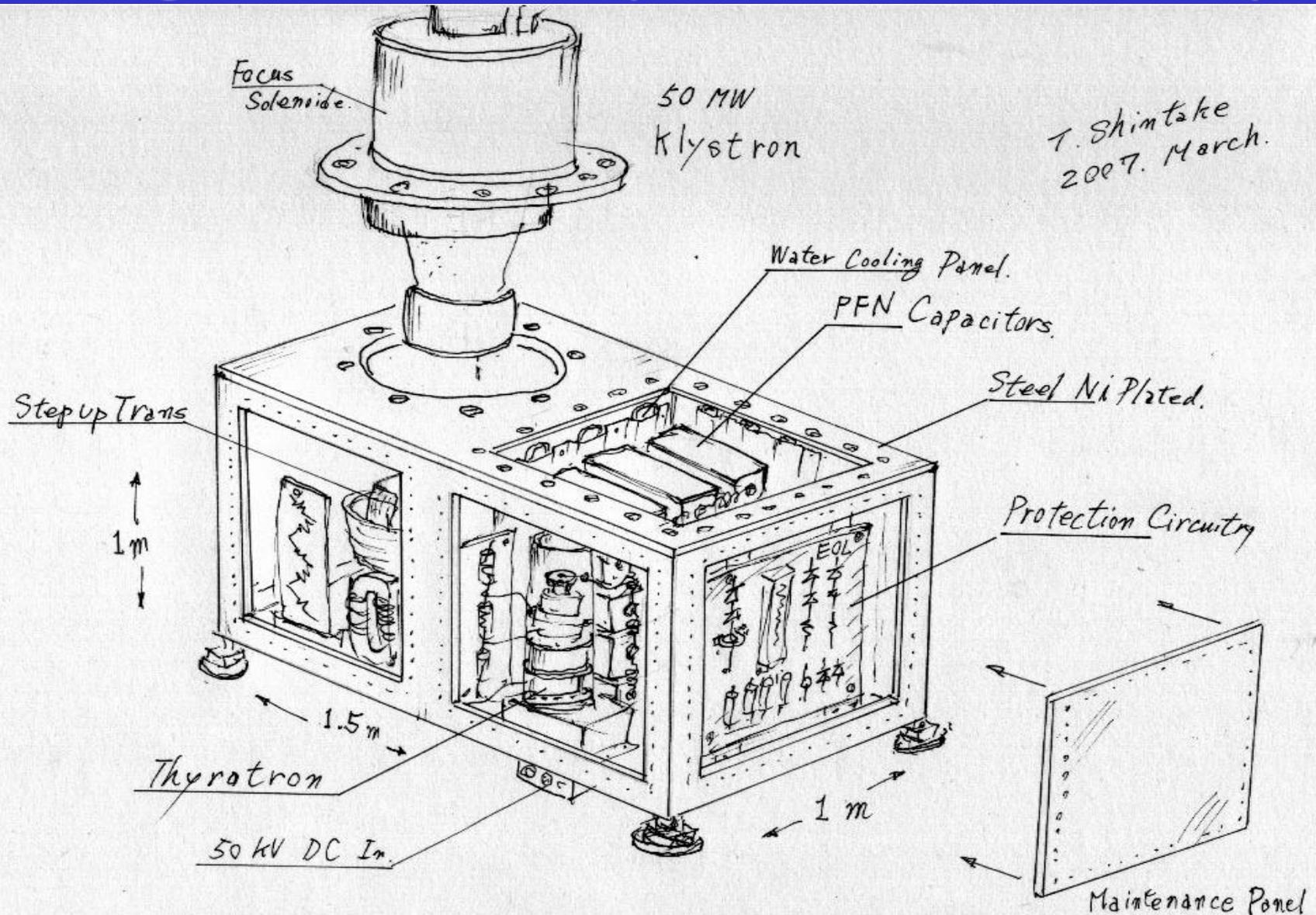
**C-band Accelerator
35 MV/m**

C-band is High Gradient (35 MV/m, max 40 MV/m)

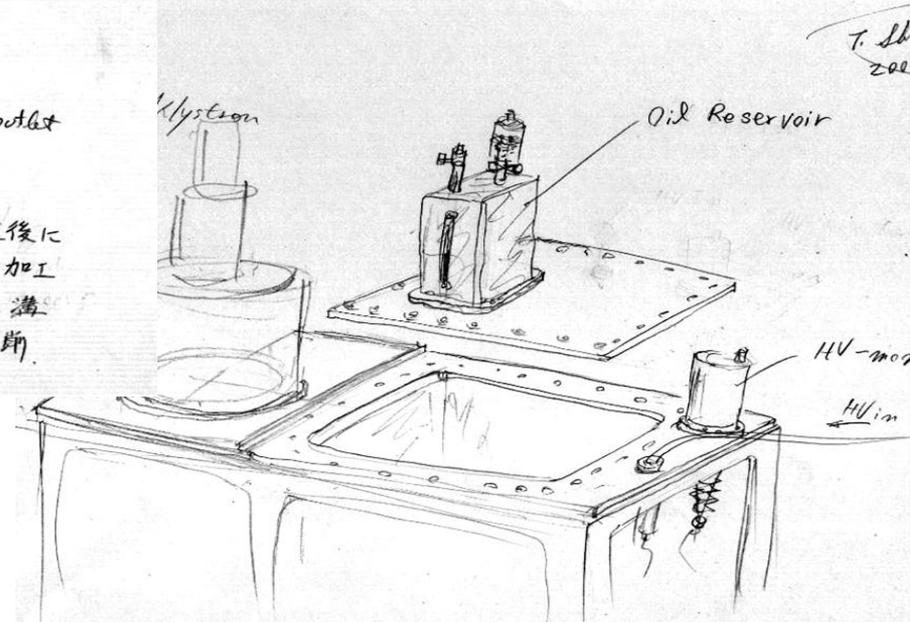
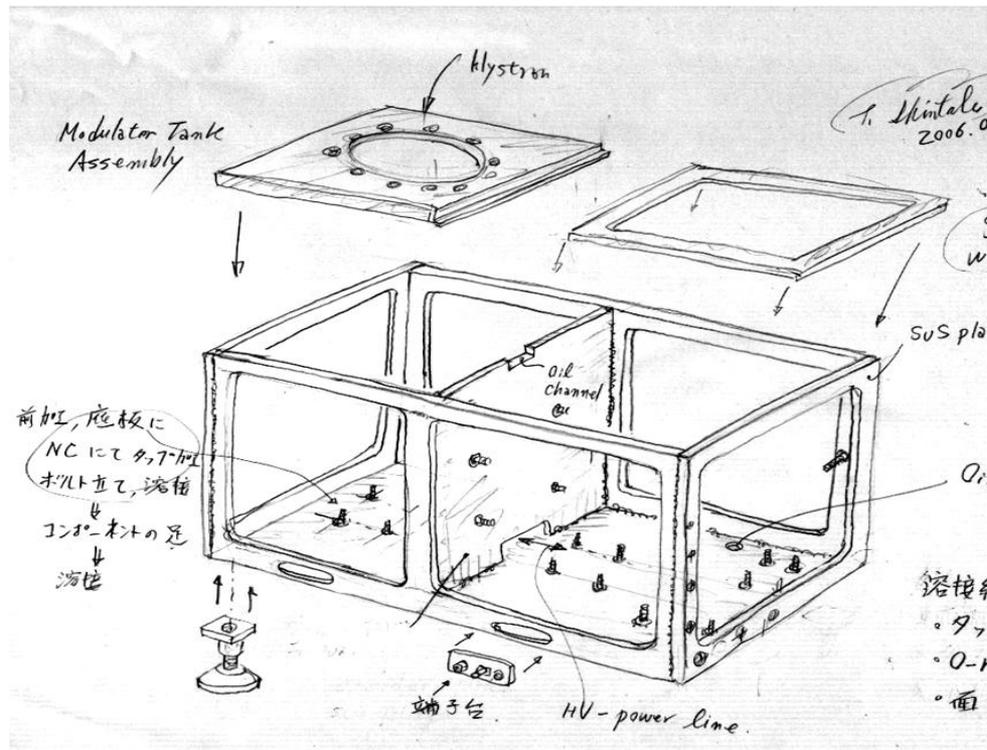
- Modulator + Control Cabinet have to fit within 3.9 m each.
→ Need to make **“Compact Modulator”**
- **High packing efficiency** = Active Length/ Actual Length
= $(1791 \times 8) / (15462+806) = 0.88$



Single Tank Modulator (PFN circuit + Transformer)



At the R&D, Ship Engine Make at AIOI contributed.



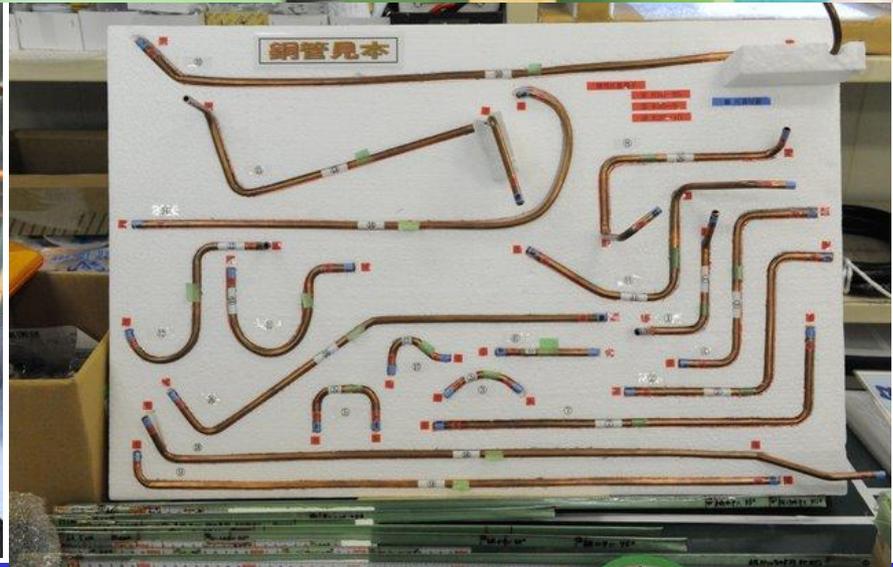
Made by steel (easier than SUS)
Suitable for mass-production.

Modulator Mass Production at NICHICON

60 modulators



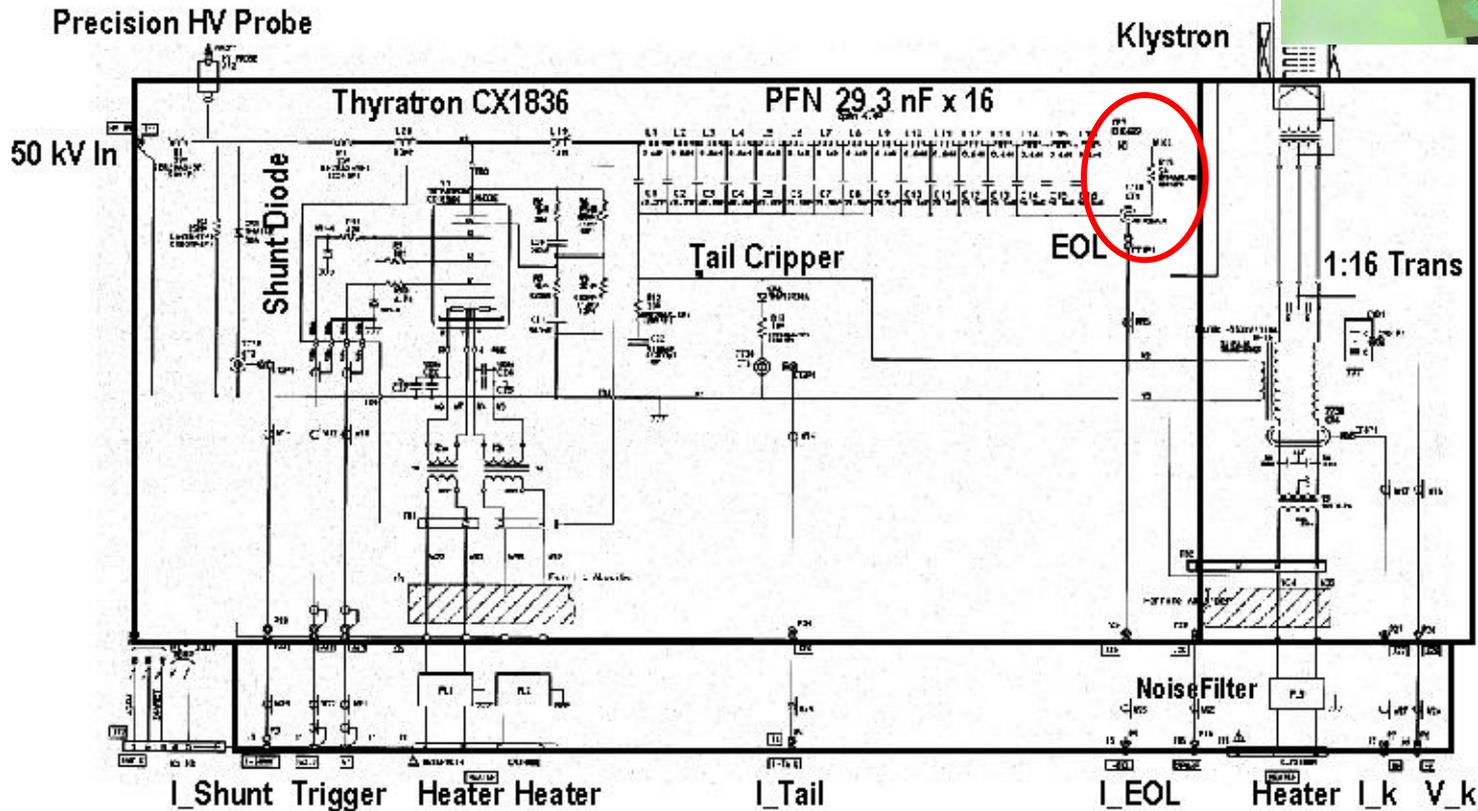
Modulator Tank Fabrication



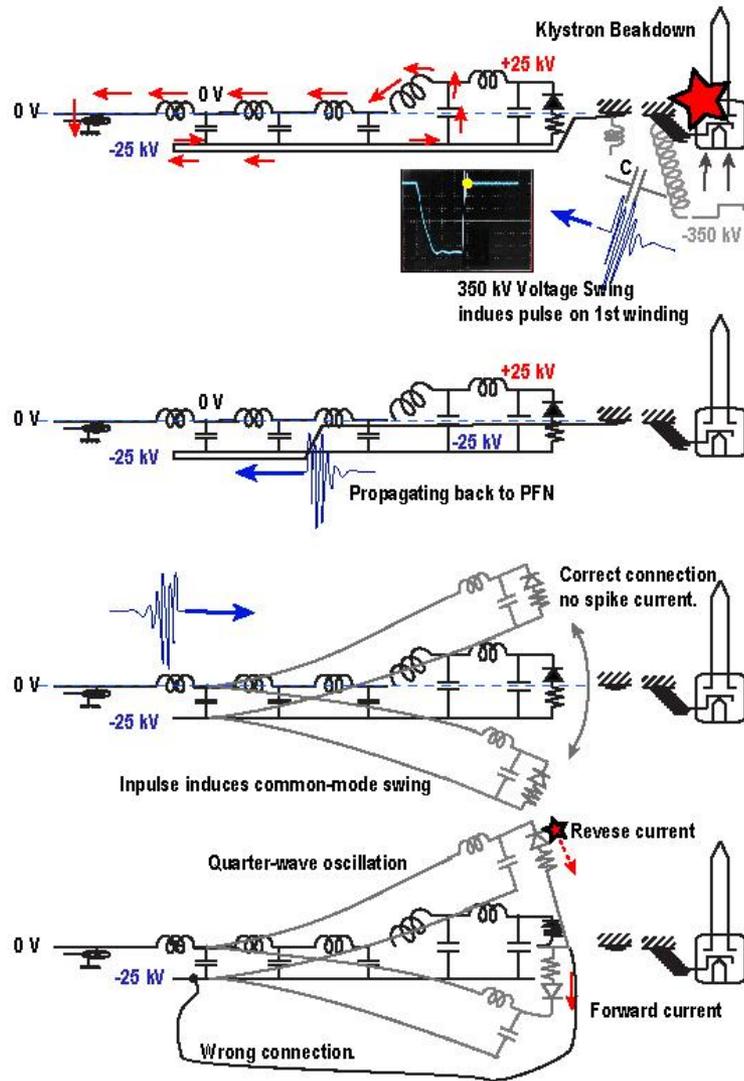
EOL Diode Failure Problem

Summer 2009

- When the klystron gun made HV break down, the EOL diodes broke. (short mode)
- Frequent failure.



Cause was wrong connection of ground line.



HV breakdown on klystron gun.



Shockwave jumps over the transformer windings, with capacitive coupling.



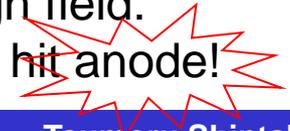
Frequency is too high ~ 100 MHz, shockwave runs ground line on PFN.



It reflects back at EOL side as open end, creates standing wave.



EOL diode turns ON very short time, then voltage reverses quickly. Before the carrier extinction time, voltage reverses, and charge remains in depletion region with high field. Charge is accelerated and hit anode!



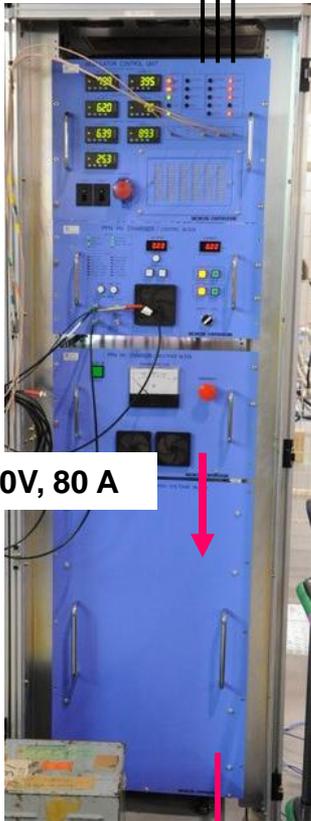


Highly Stable Inverter Type PFN Charger for stable operation of XFEL.

- High power capacitor charging system.
- 1.8 Apeak at 50 kV
- Pulse to Pulse < 100 ppm.pp

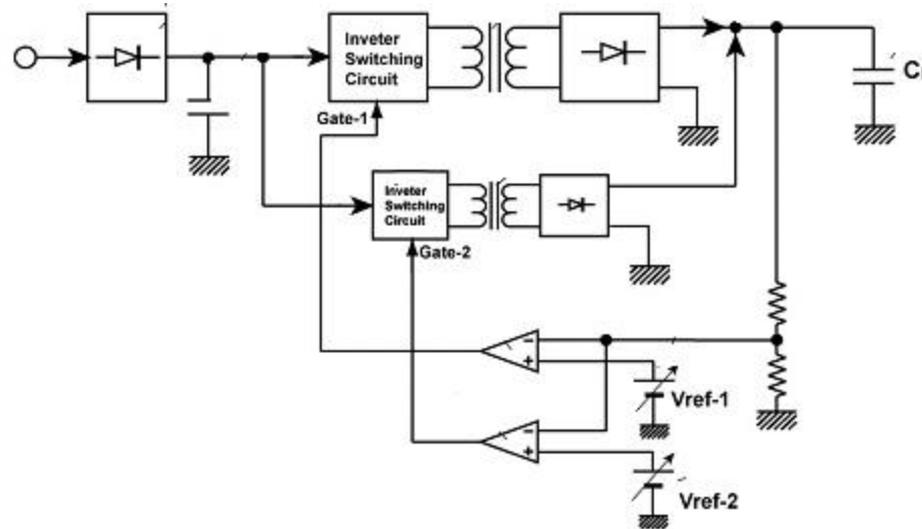
- Main Switching at 20 kHz, IGBT
- Sub switching at 80 kHz, FET

400 V, 3 ϕ

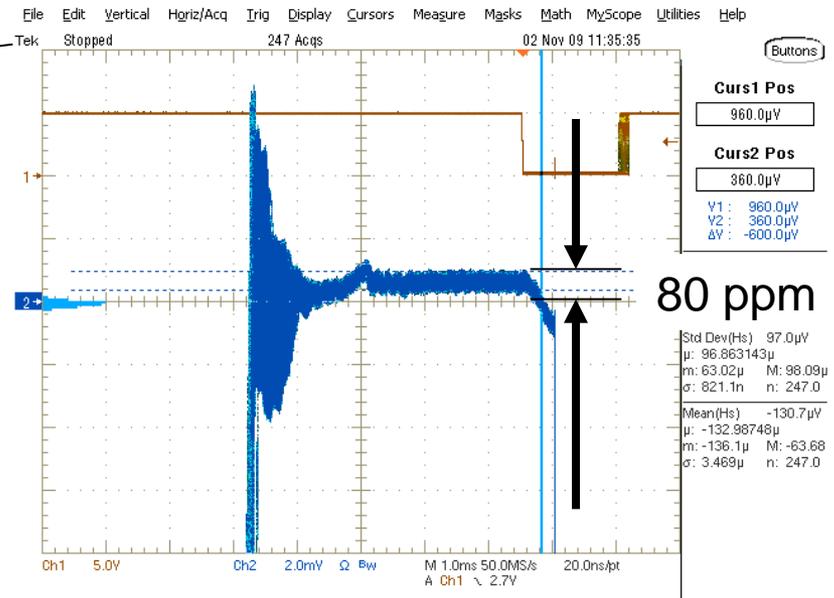
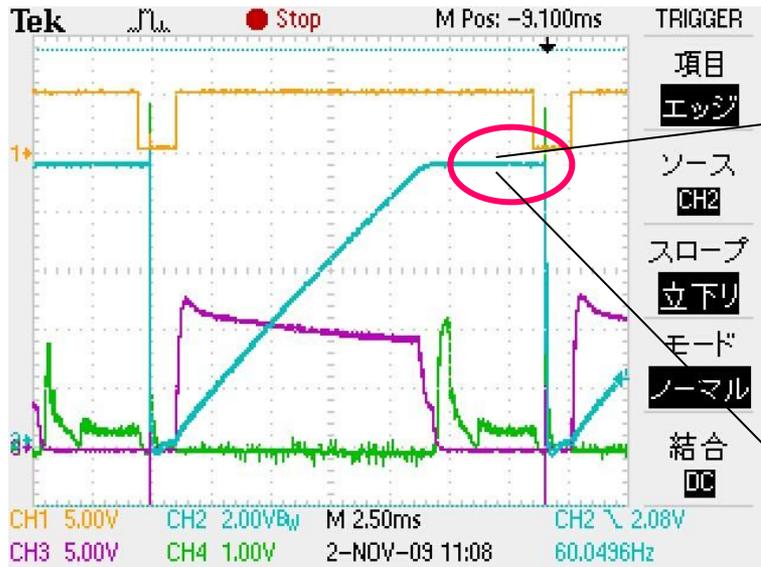


600V, 80 A

Highly stable
PFN charger
< 100 PPMp-p

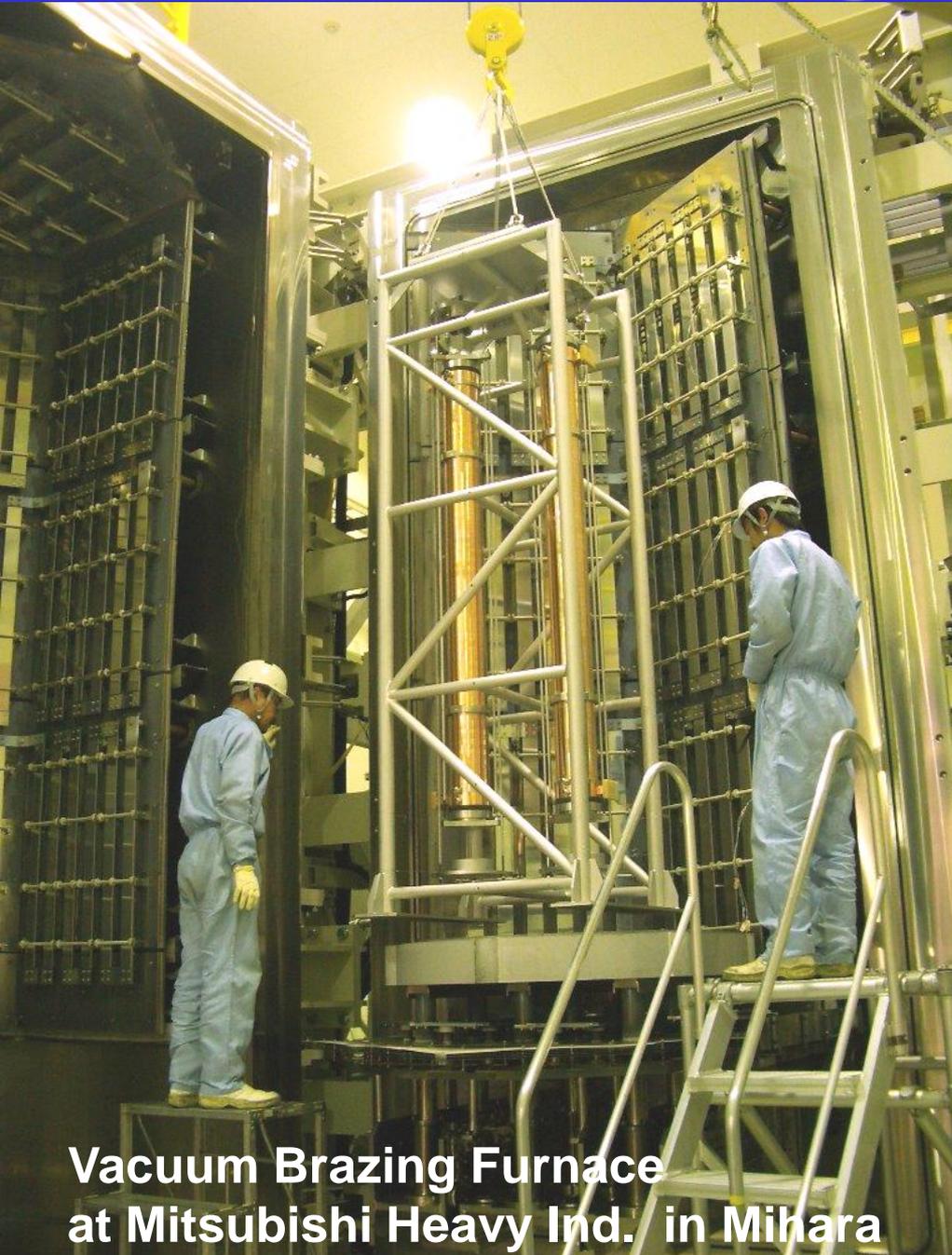


When voltage approaches to target, sub-inverter controls the voltage in fine mode.



- Achieved PFN Charging voltage stability
 - 80 ppm (peak-peak) for 1 minute
 - 190 ppm (peak-peak) for 8 hours.

Brazing of C-band Accelerators



- A number of technical improvements have been made.
- 1~2 columns per week.

Vacuum Brazing Furnace
at Mitsubishi Heavy Ind. in Mihara

Tsumoru Shintake
shintake@spring8.or.jp

Mass-production of
128 tubes of the C-band Accelerating Structure for 8
GeV linac.
@ MITSUBISHI Heavy Ind.



**MITSUBISHI-Team completed 100 tubes (out of 128) C-band Accelerator.
Photo March 2009**



Routinely Operation: C-band High Gradient Test

T. Sakurai, IPAC2010

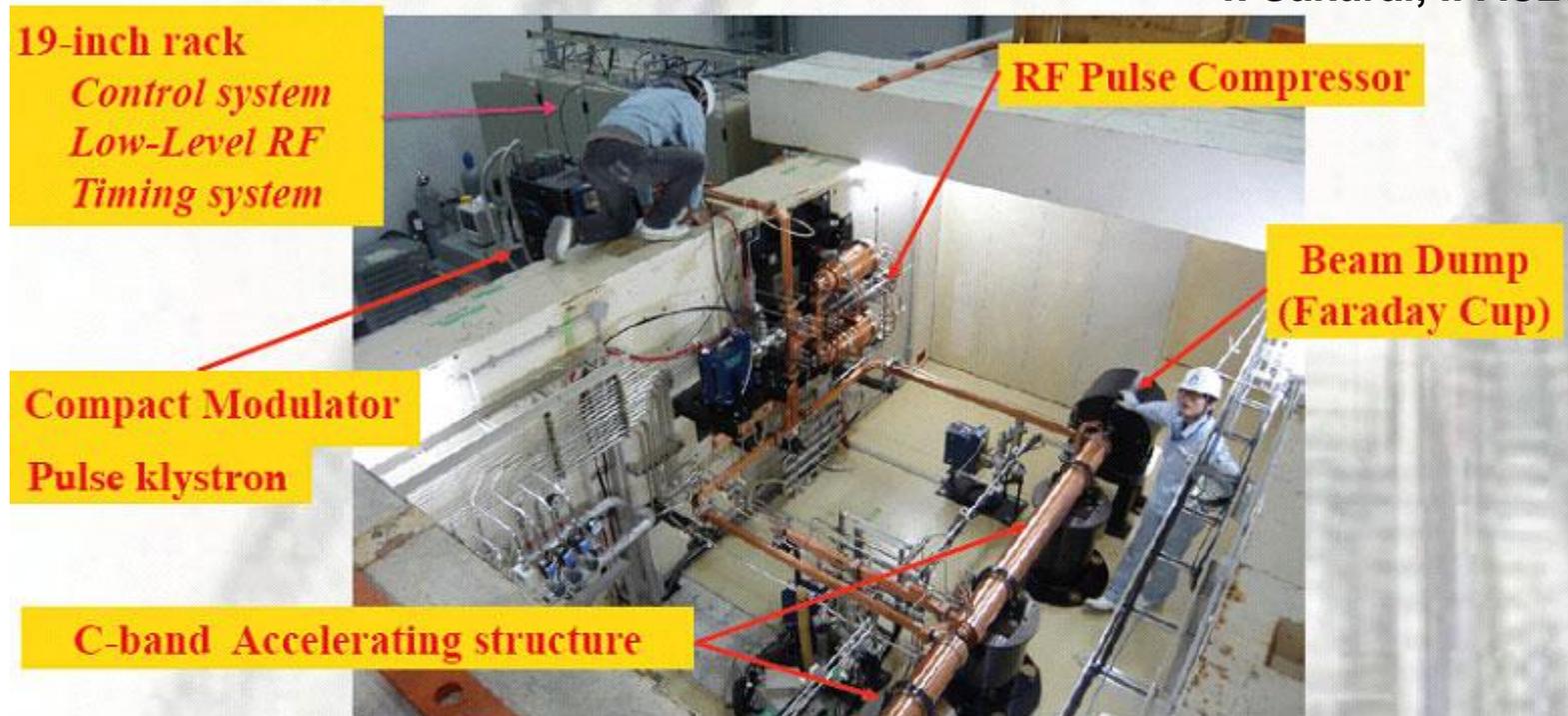


Fig.2 Birds' eye view of the test bunker.

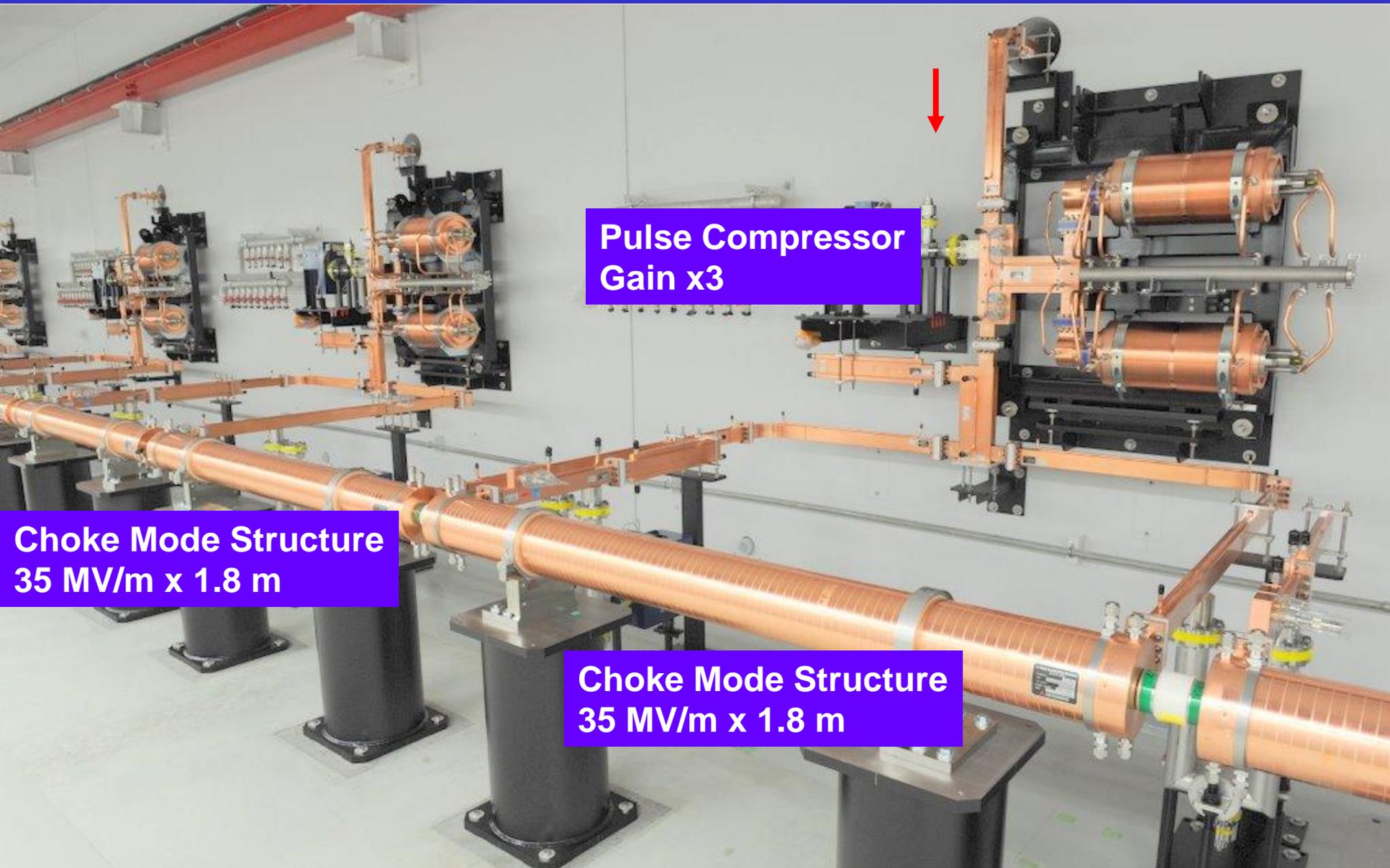
RF Pulse Compressor
 $Q_0 : > 180000$, $\beta : > 8.0$
Two TE_{0,1,15} cavities
RF power Gain : (typ.) 3

- Sample test from mass production.
- C-band 1 unit for one month.
- 35 MV/m is routinely achieved.
(Very low trip rate.)
- Processing up to 40 MV/m, 60 pps.

Installed C-band Accelerator



C-band Accelerator



Pulse Compressor
Gain x3

Choke Mode Structure
35 MV/m x 1.8 m

Choke Mode Structure
35 MV/m x 1.8 m

Summary

- CeB6 thermionic performance was fully investigated, and found to be matched to XFEL/SPring-8.
- Various new hardware components have been developed in this laboratory, LLRF, single-tank klystron modulator, high precision power supply, etc.
 - Those components will be useful to other accelerator projects including FELs, light source injectors and also ERLs.
- We will contribute to accomplish X-ray lasing of XFEL/SPring-8, expected Summer 2010.
- This laboratory will keep activity for future upgrade of XFEL/SPring-8.

Acknowledgement

- We would like to acknowledge to all of colleague here and also from outside for their various help and encouragements to our laboratory.
- We wish thank to people from industries for their collaborative efforts on development of all hardware components.
- We would like to say thank to people at secretaries office in this institute, and director office.